

FIG. 1

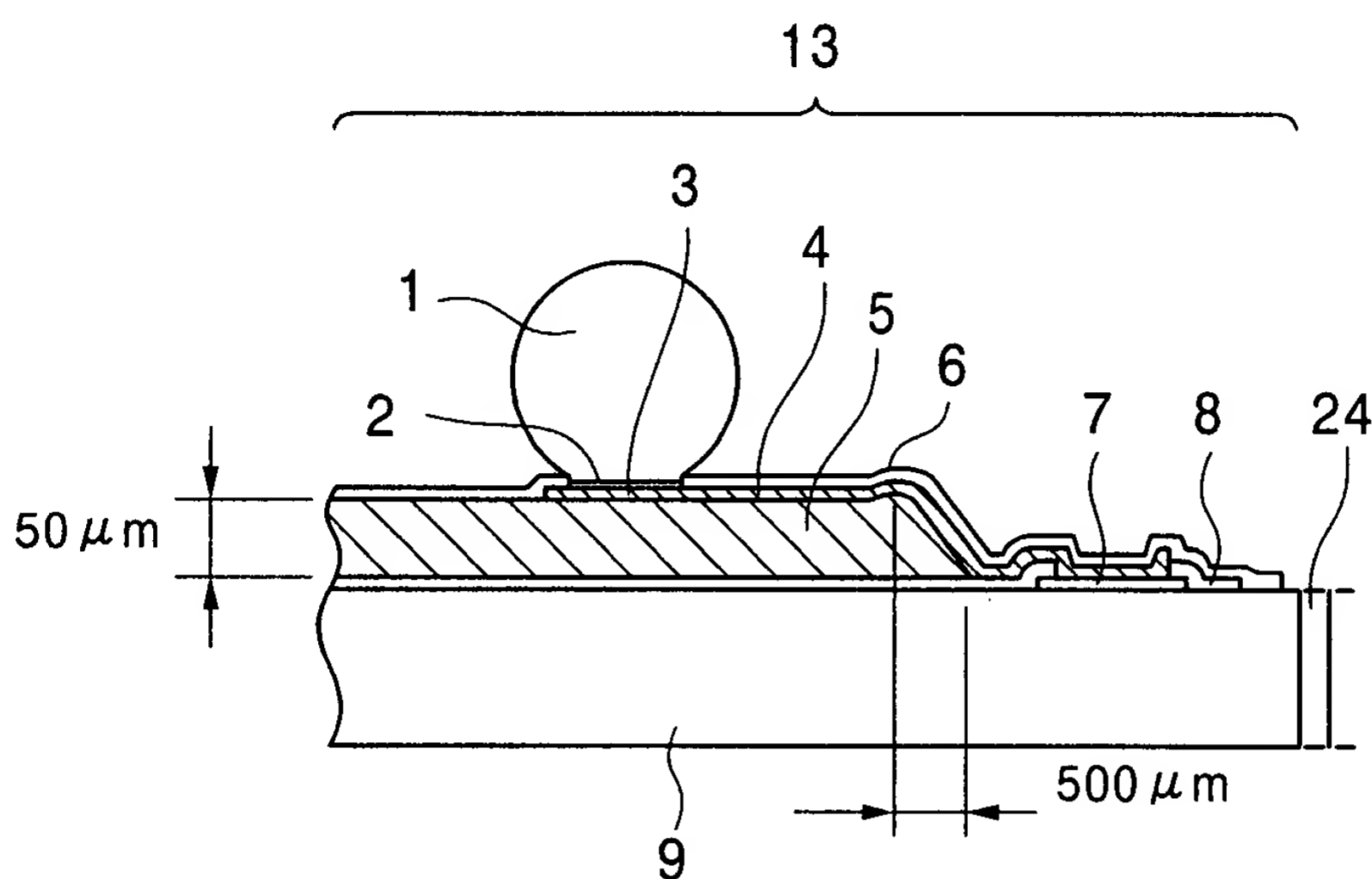


FIG. 2

6 (HATCHED PORTION) 18

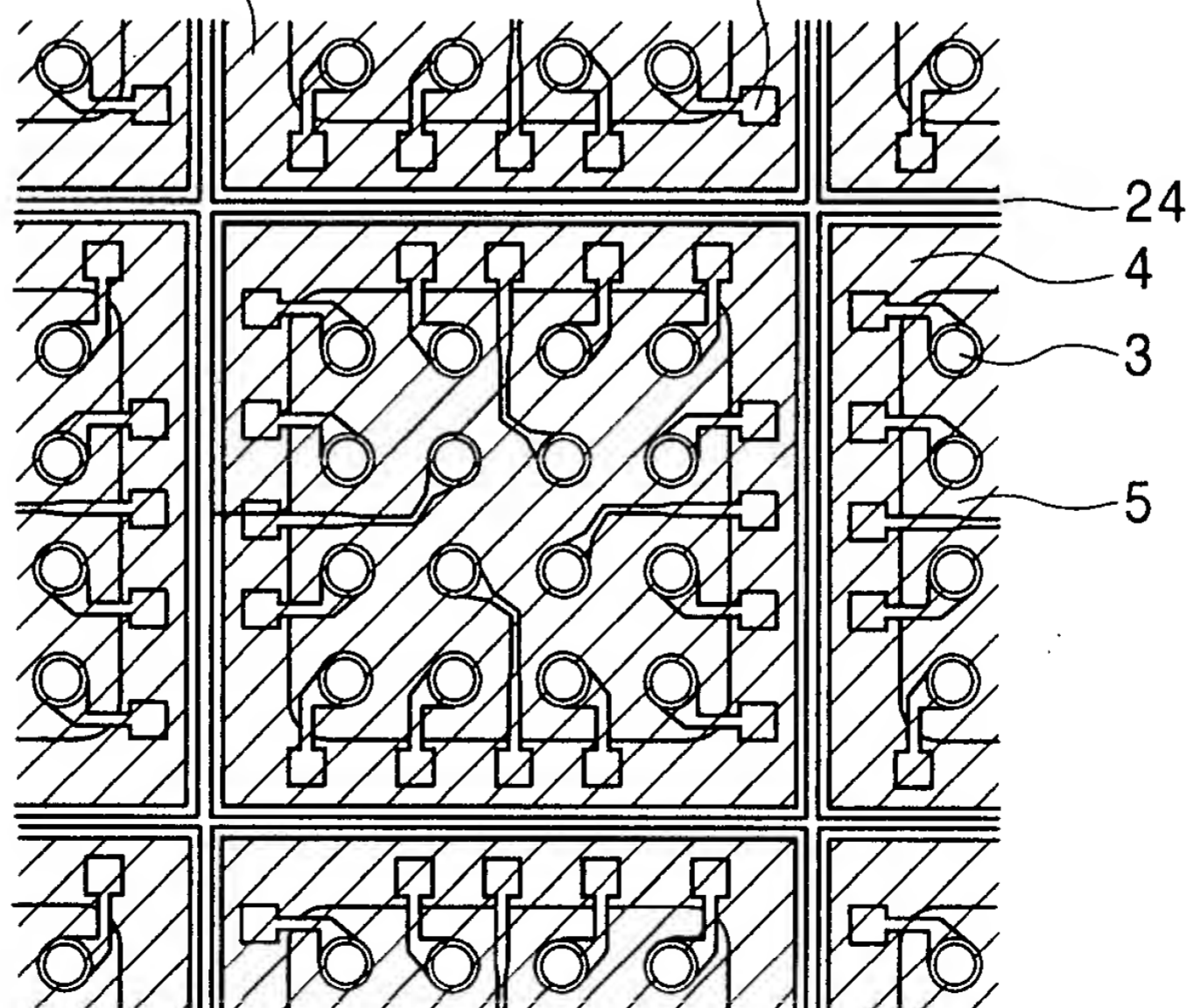


FIG. 3

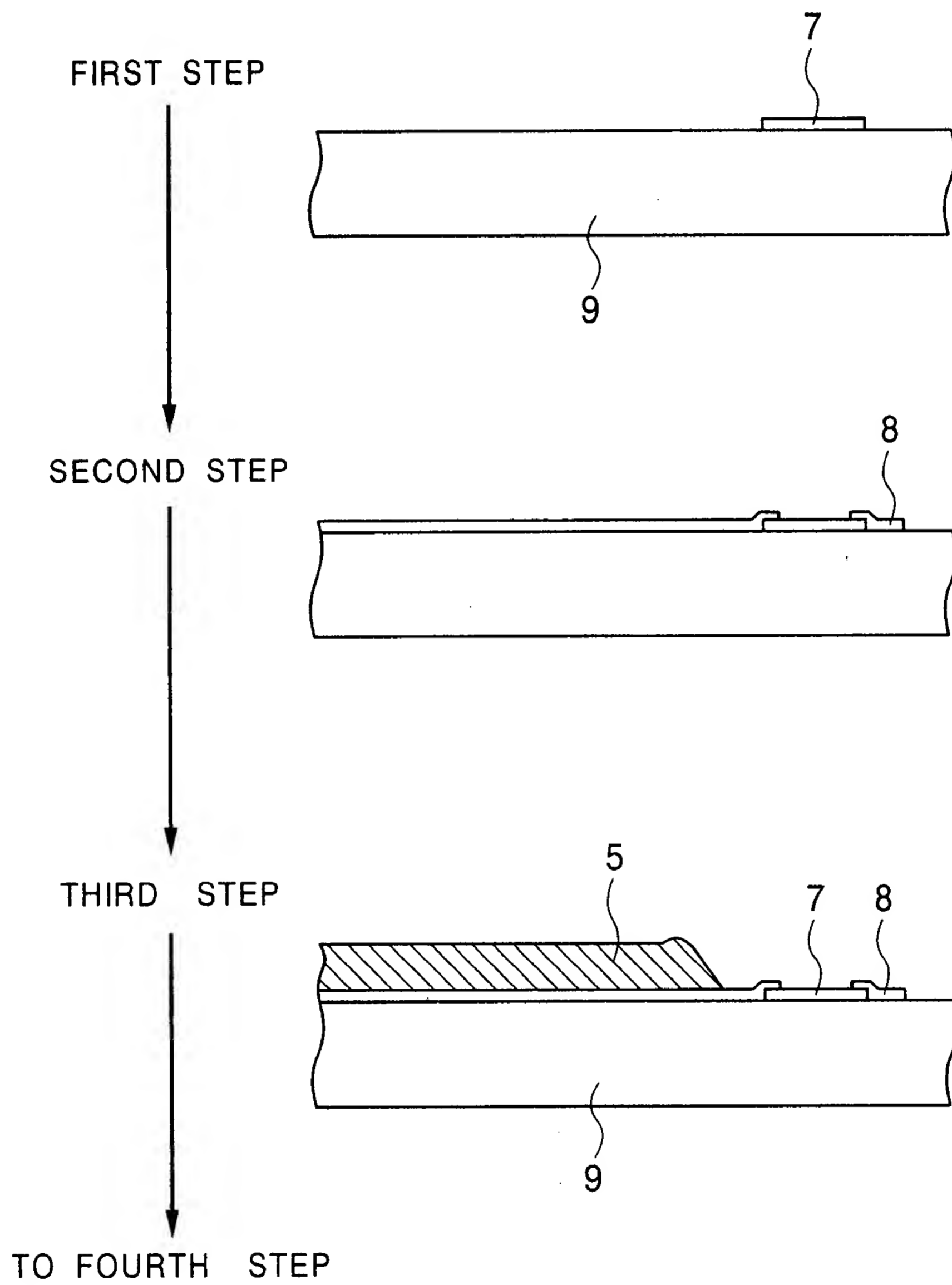
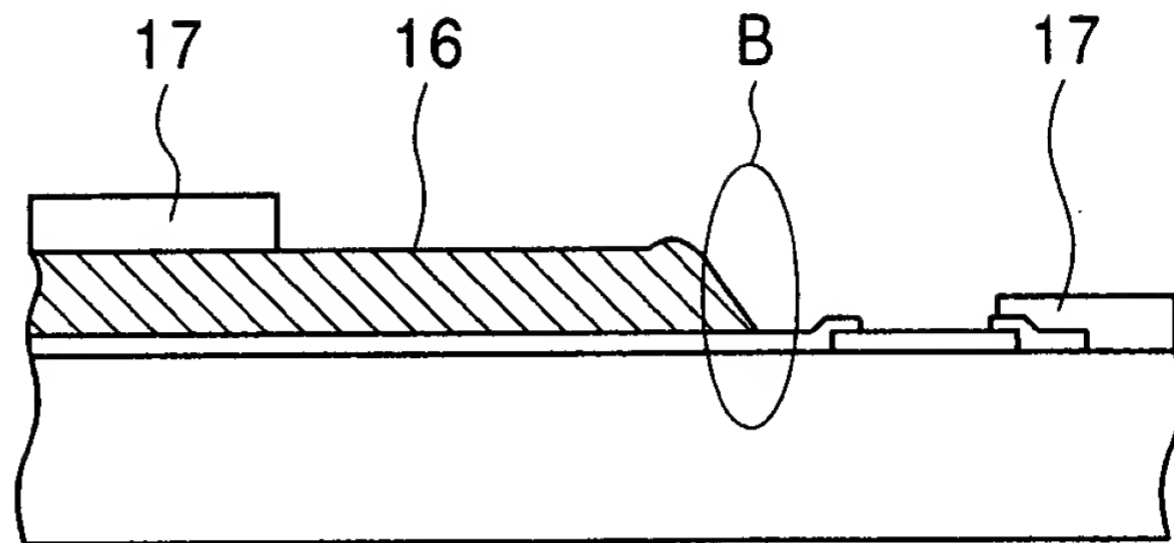
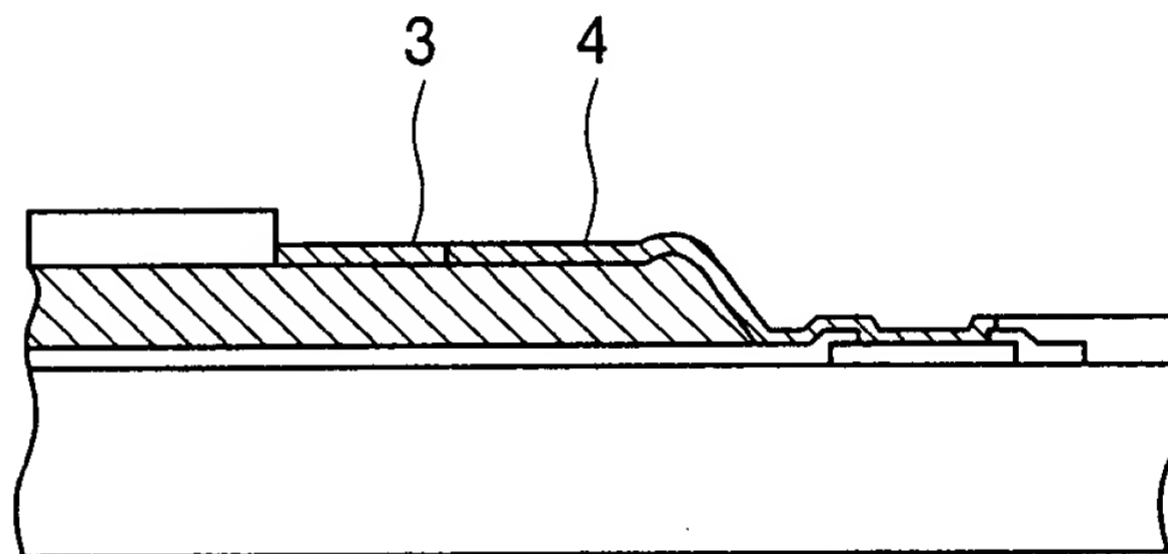


FIG. 4

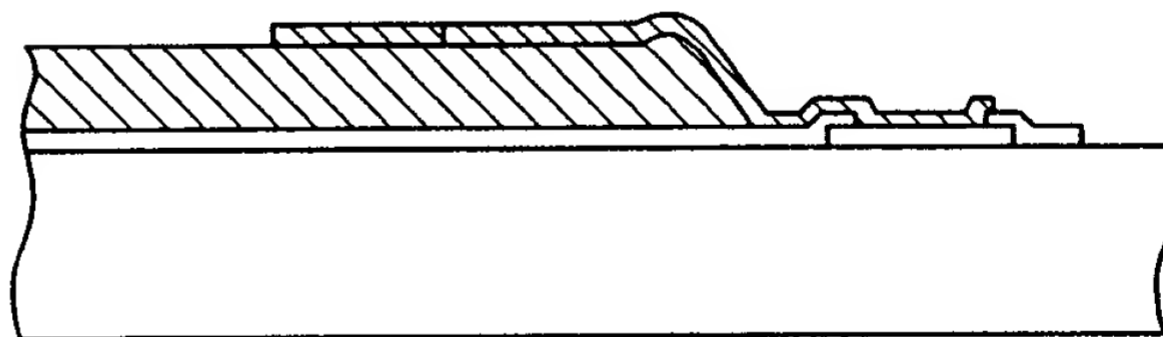
FOURTH STEP



FIFTH STEP



SIXTH STEP

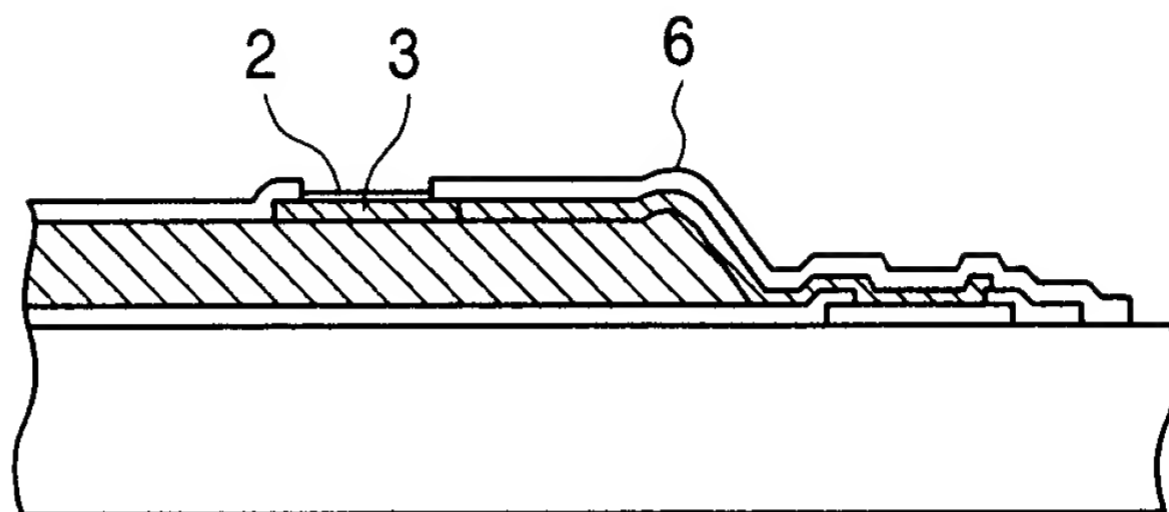


TO SEVENTH STEP

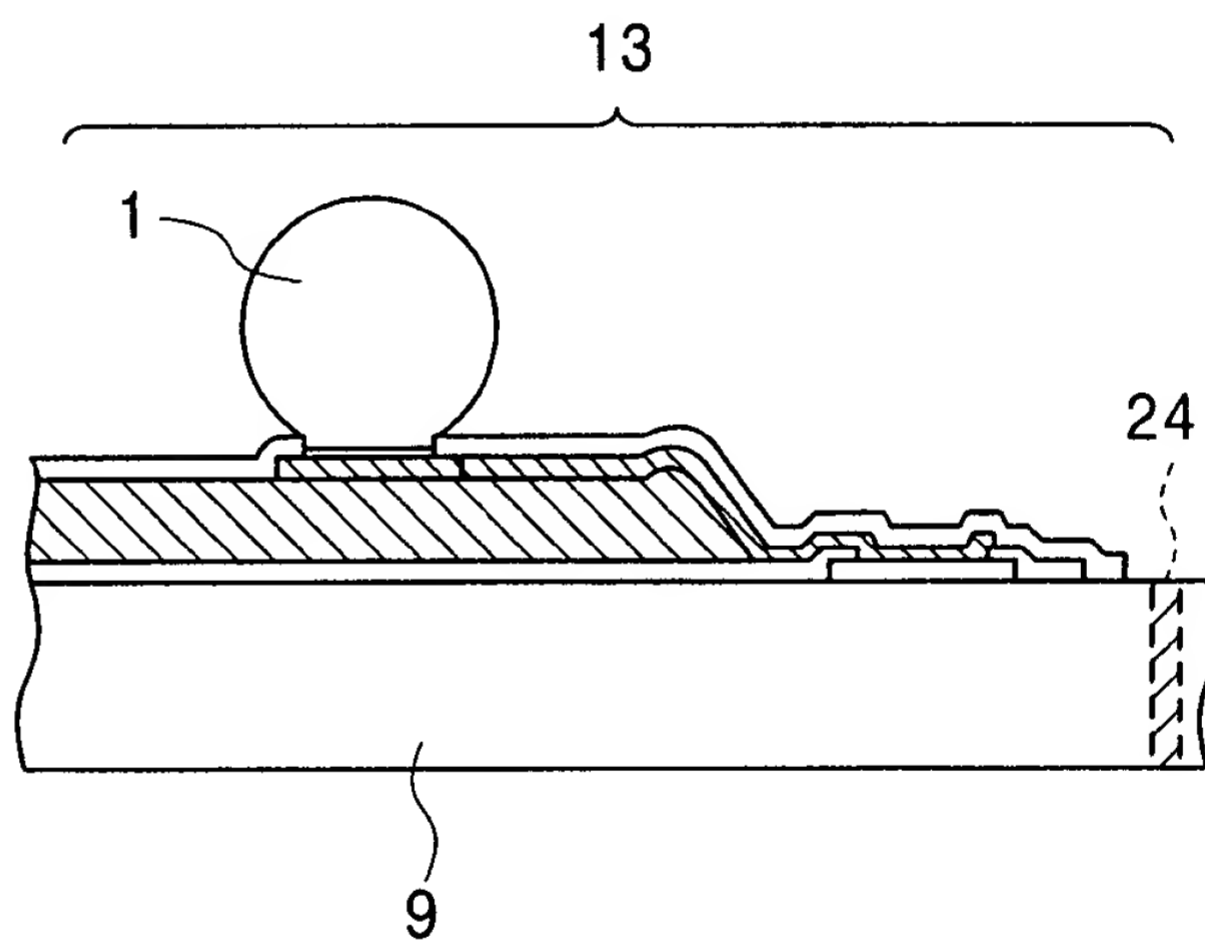
00000135360

FIG. 5

SEVENTH STEP

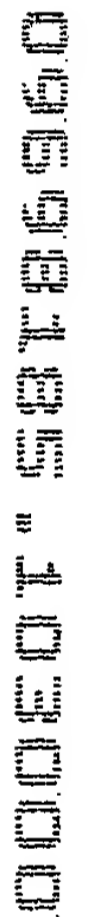


EIGHTH AND
NINTH STEP

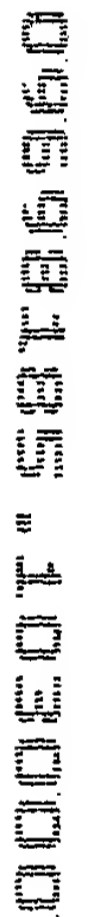


COMPLETE

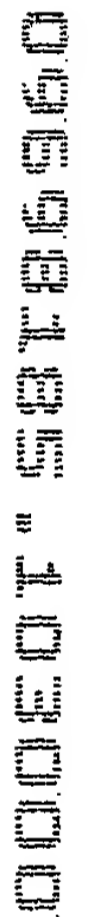
SECRET



SECRET



SECRET



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FIG. 9

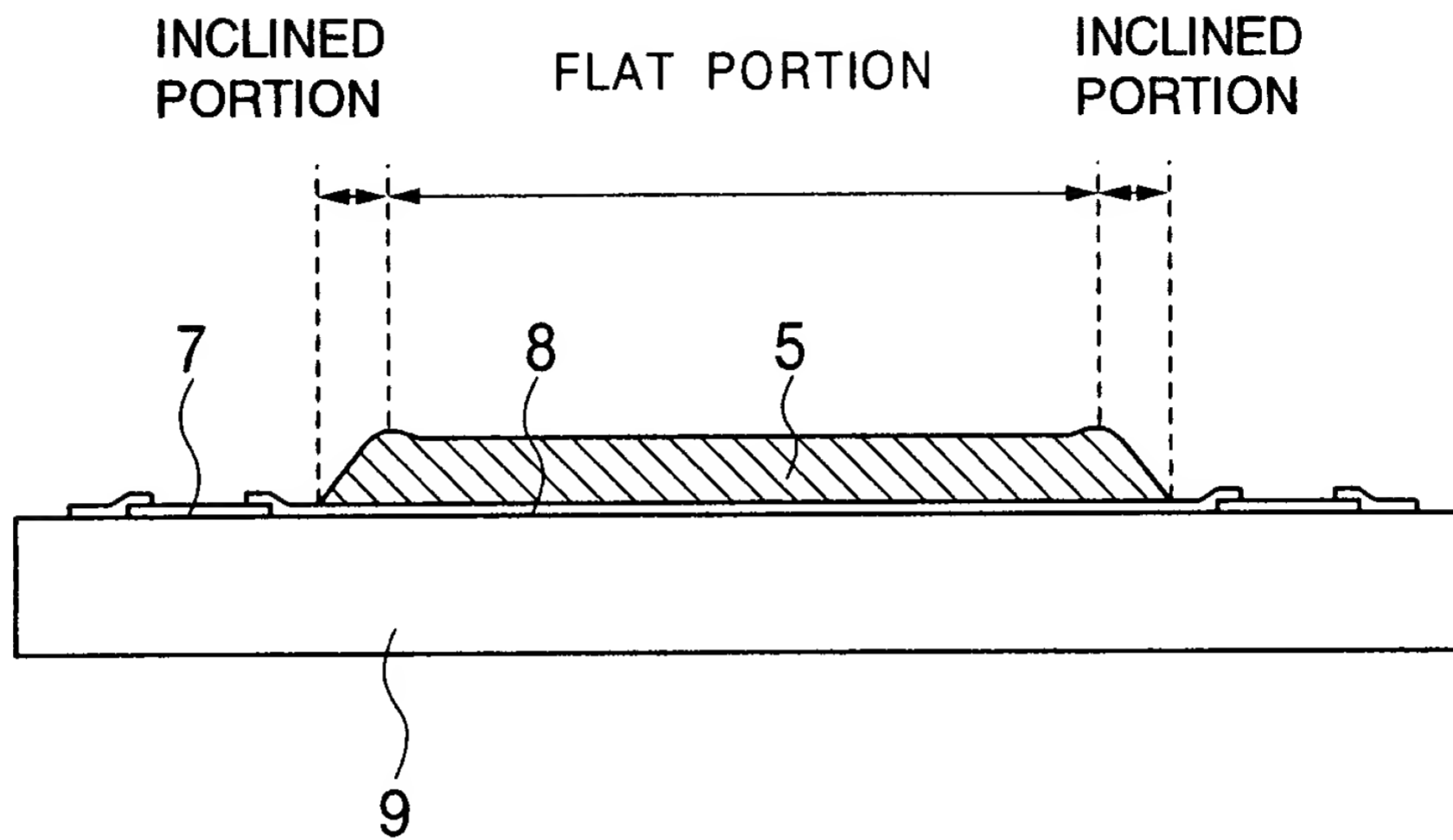


FIG. 10

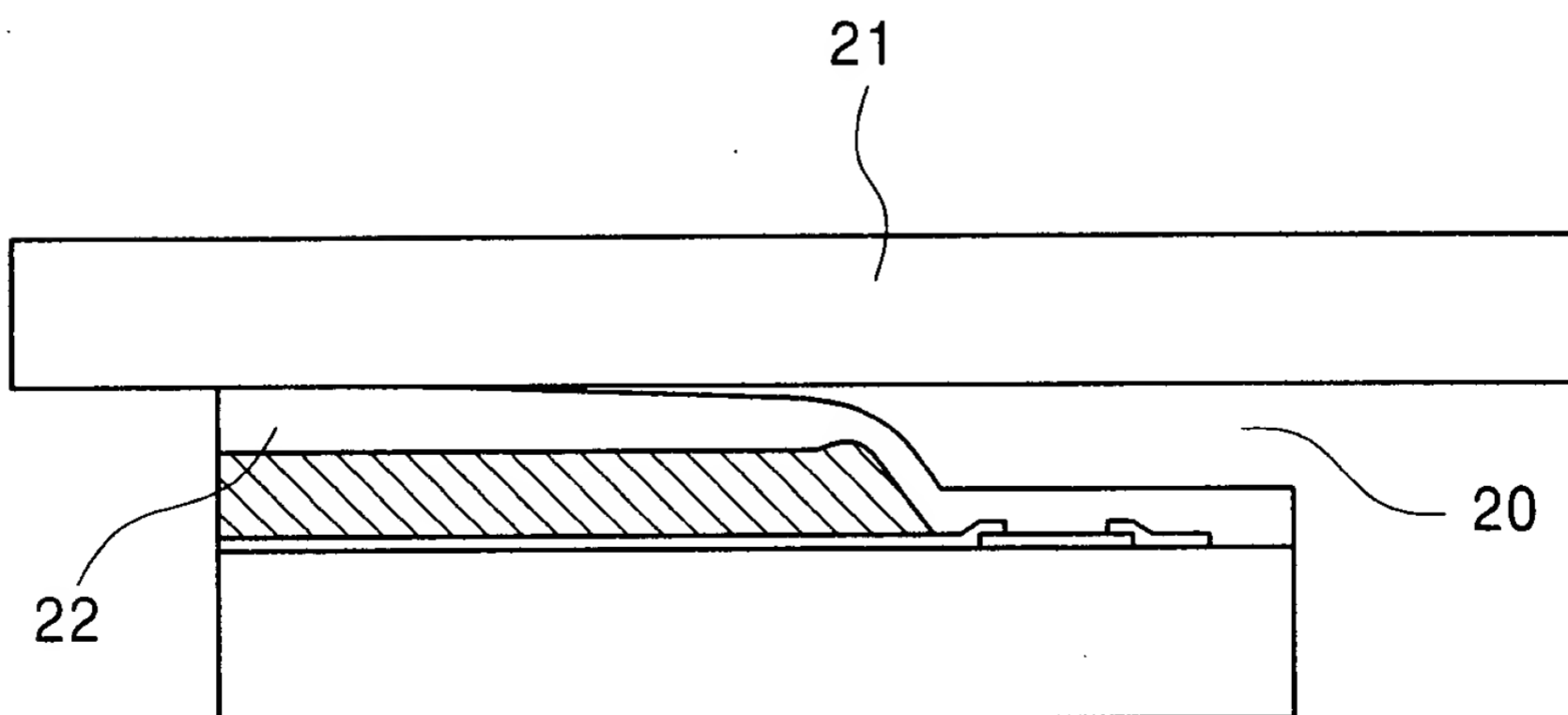


FIG. 11

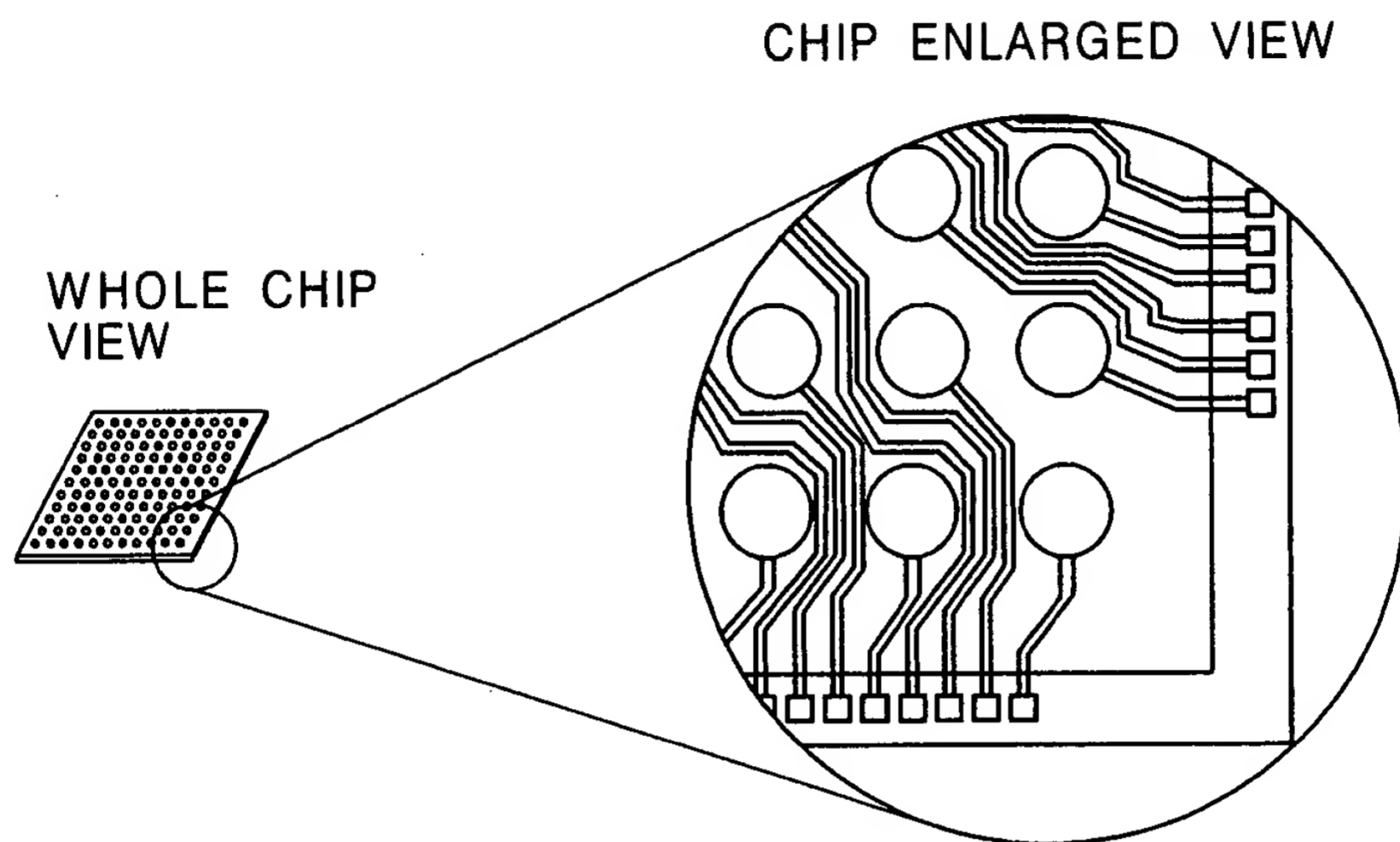


FIG. 12

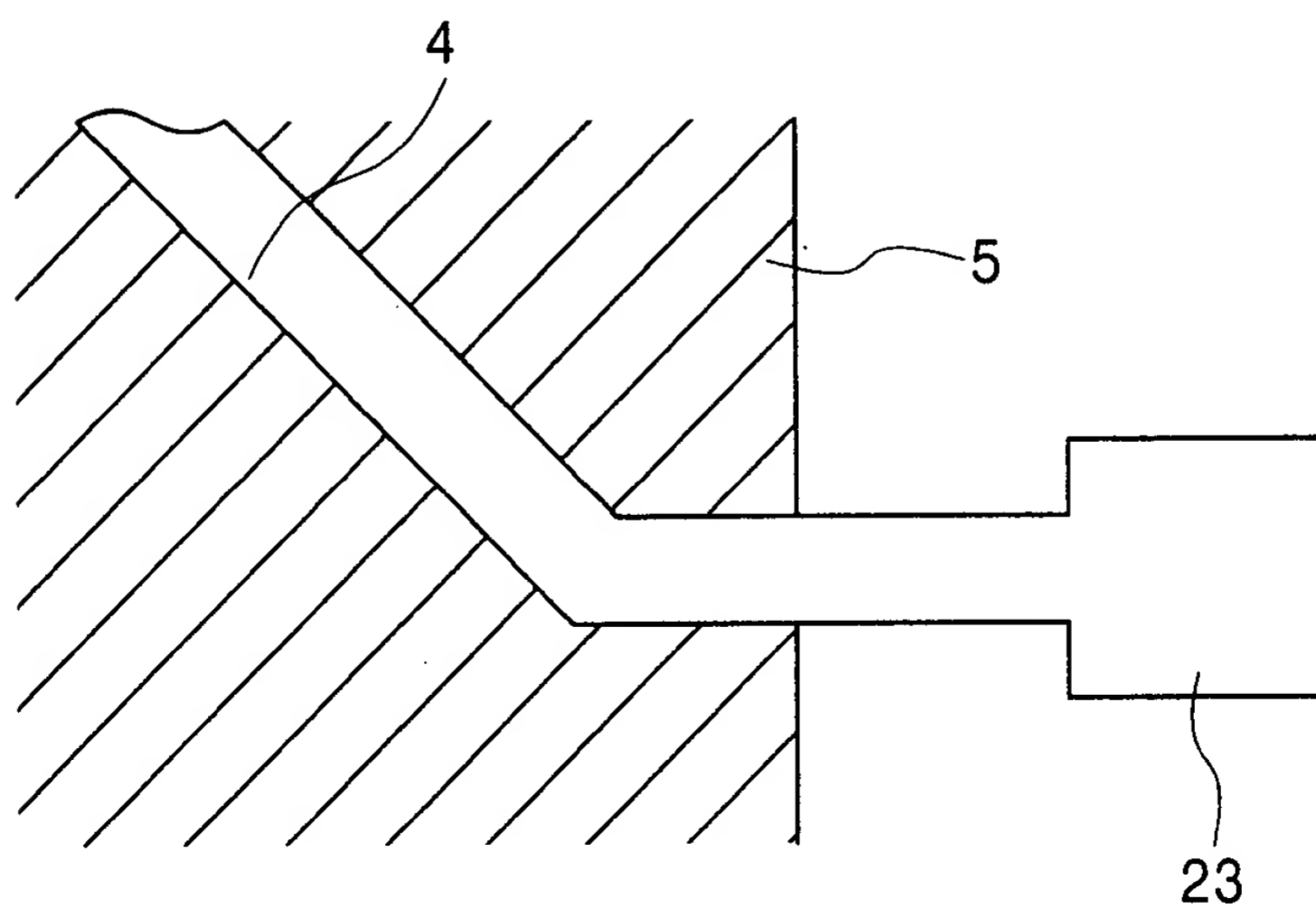


FIG. 13

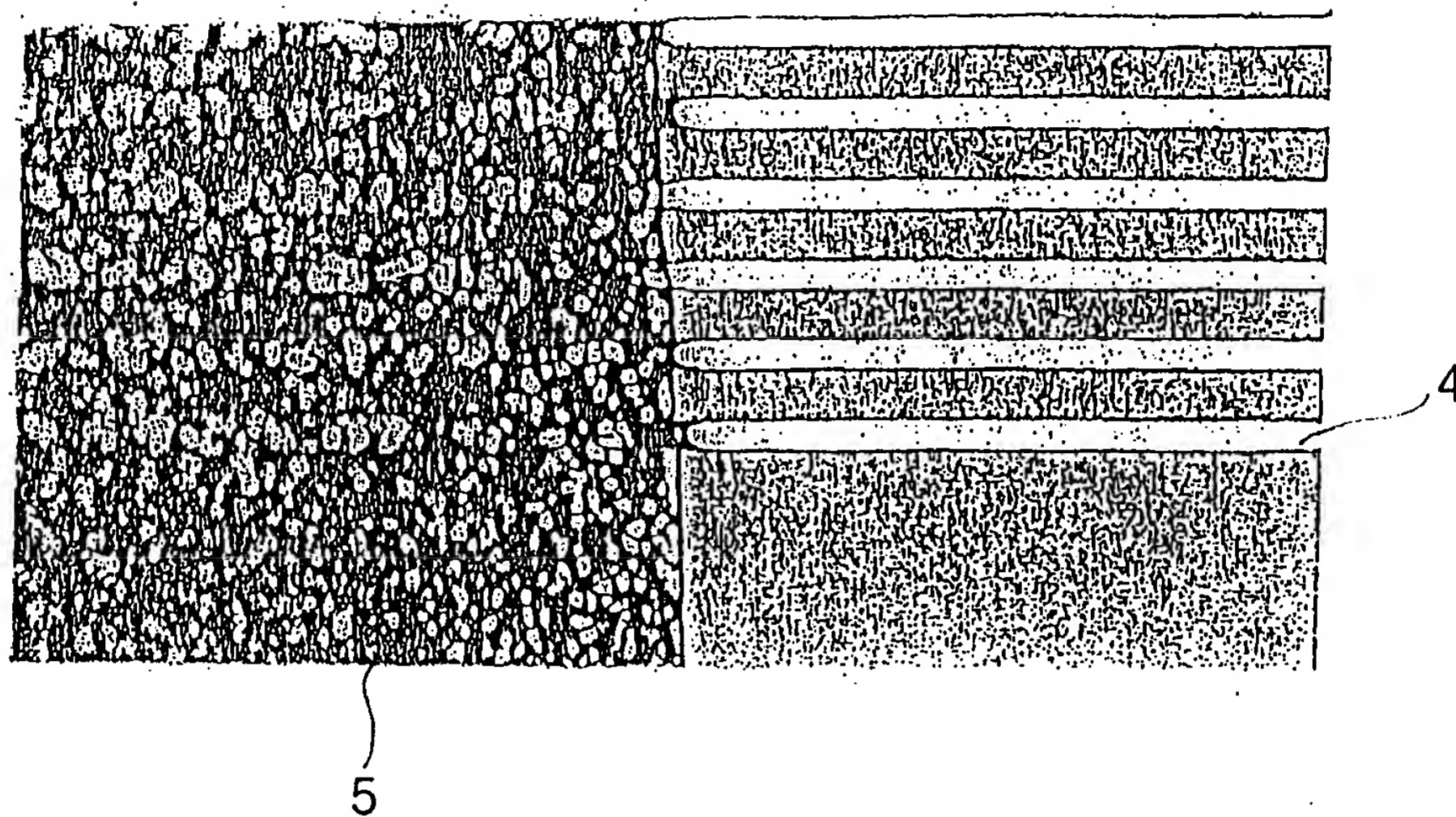


FIG. 14

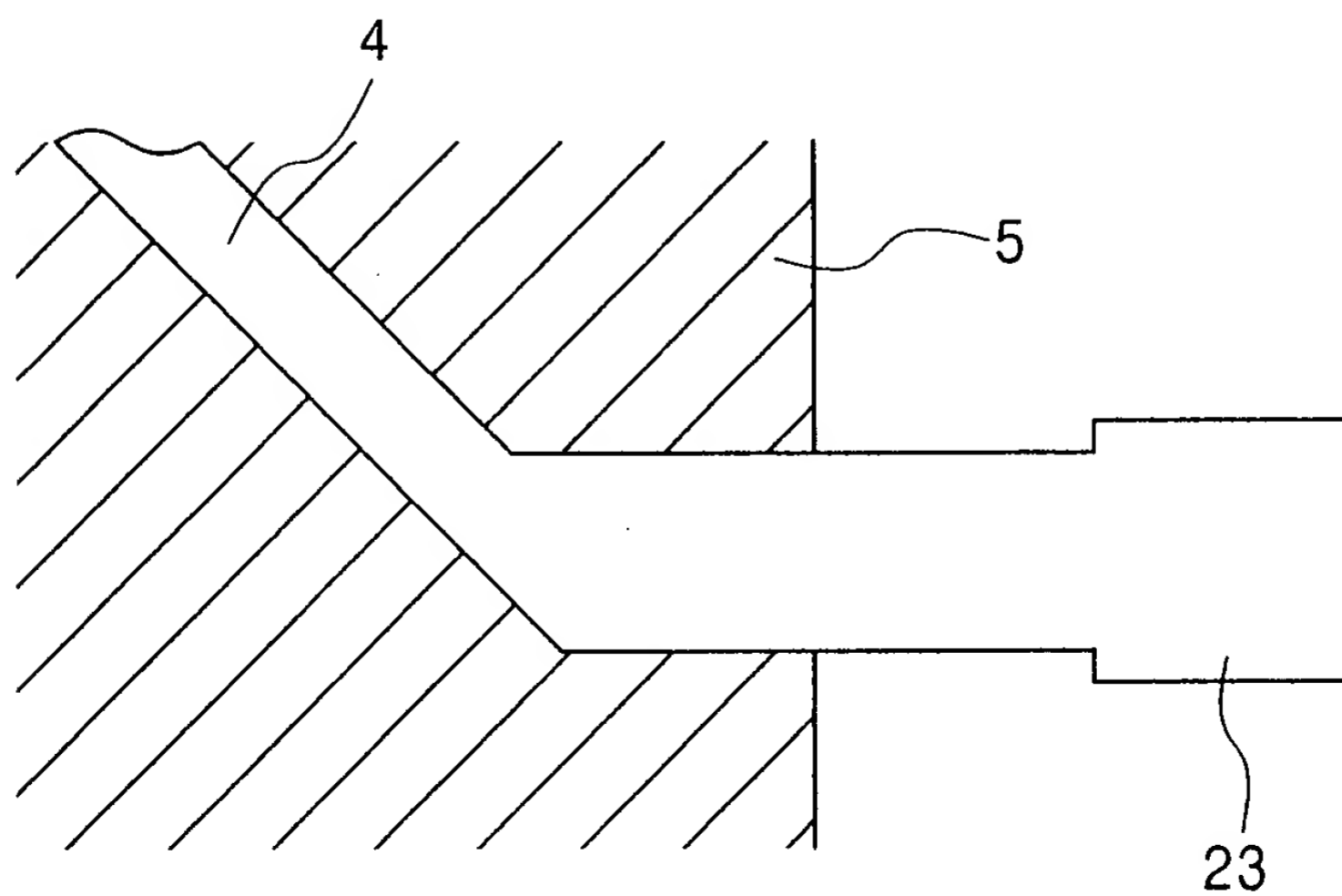
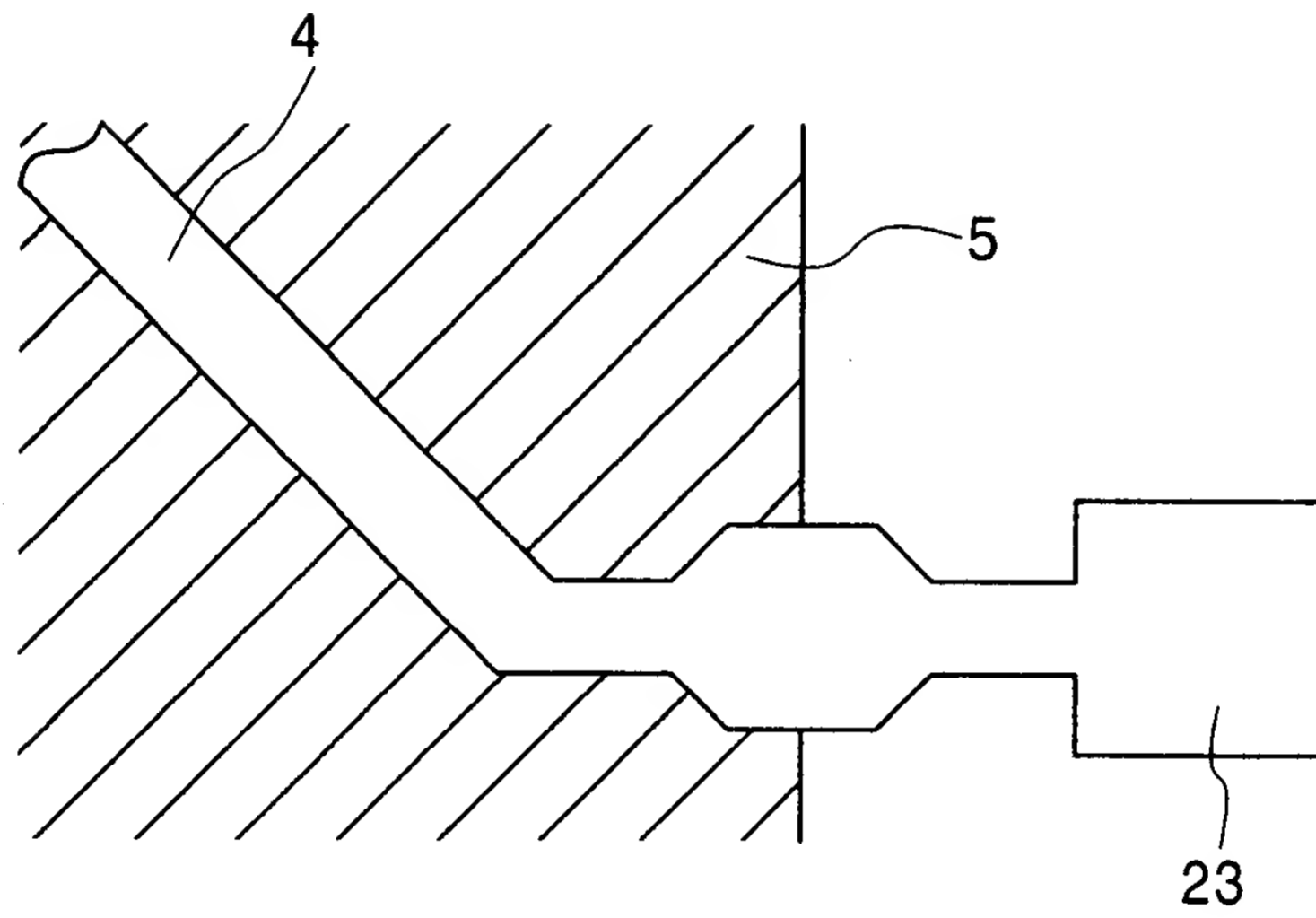


FIG. 15



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FIG. 17

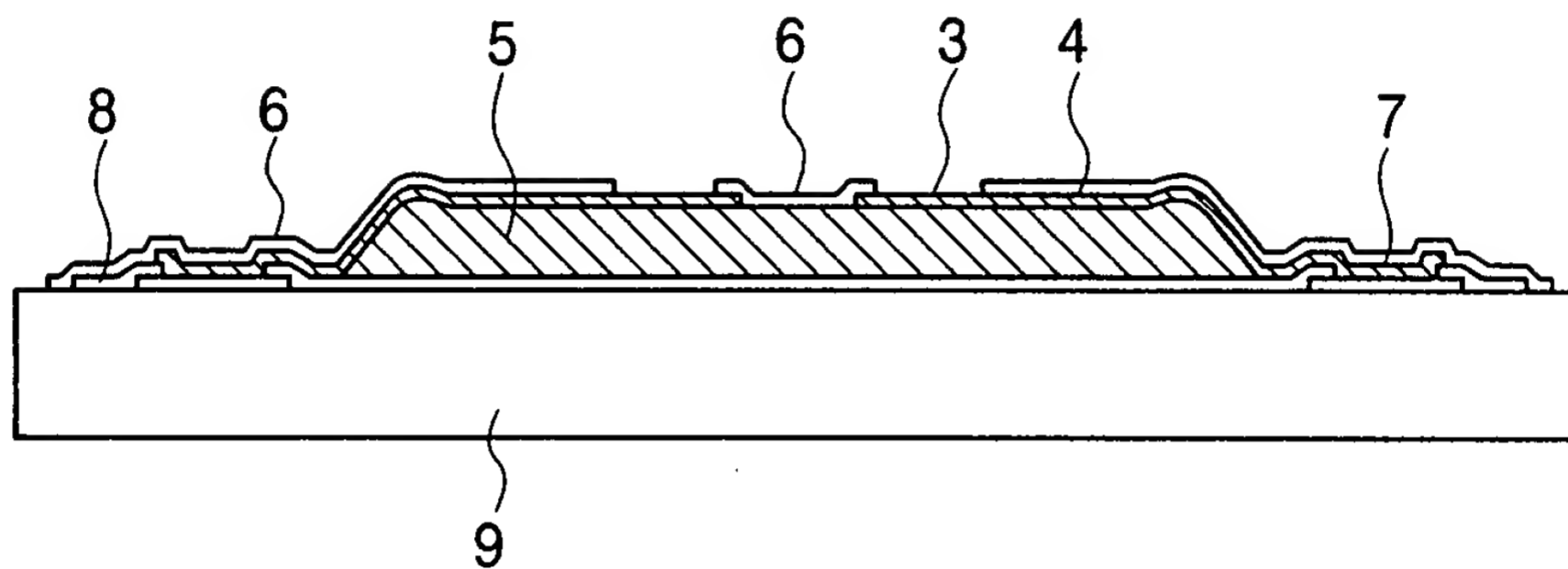
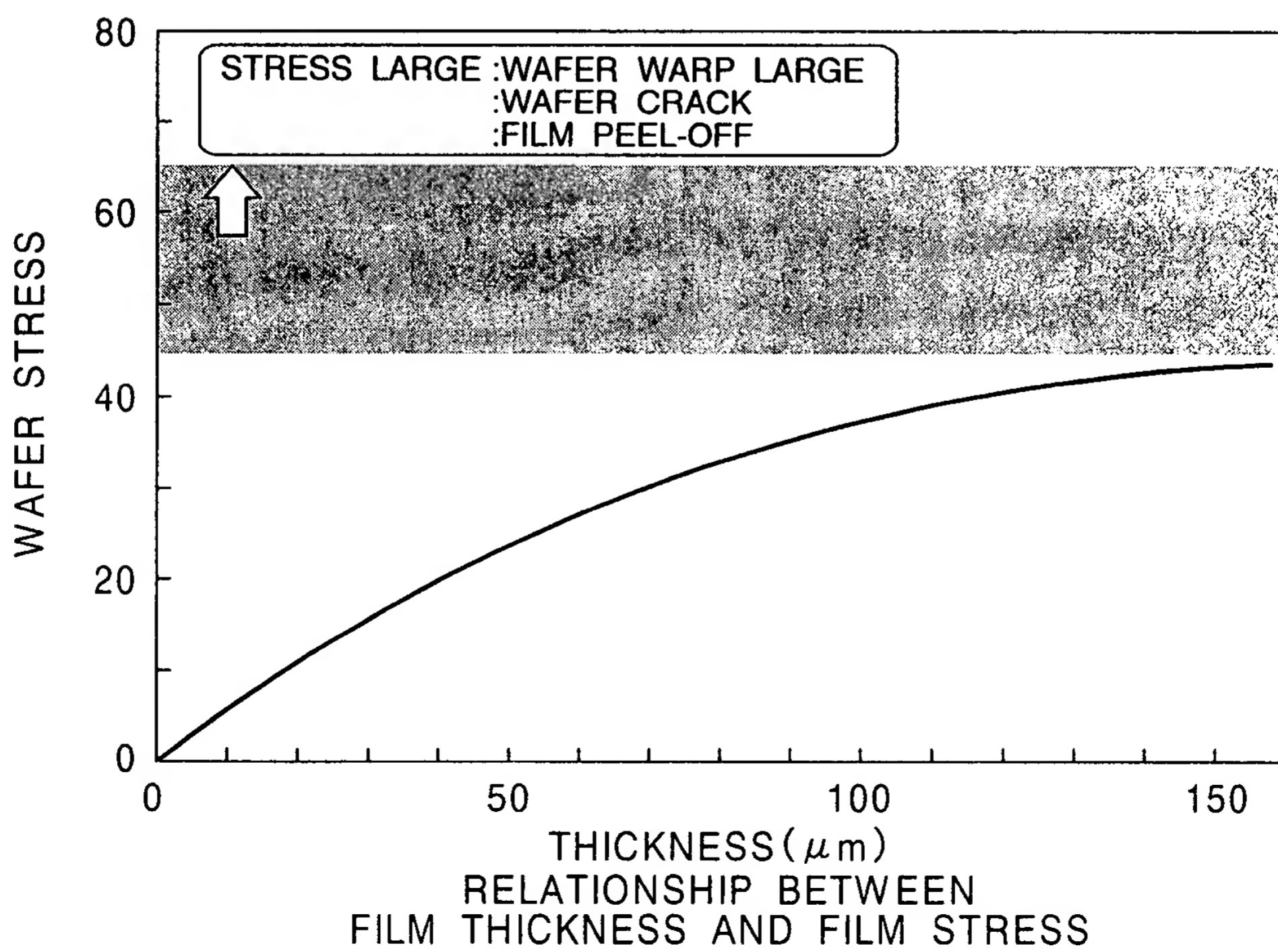
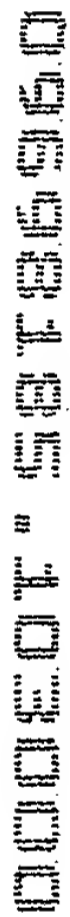


FIG. 18



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FIG. 21

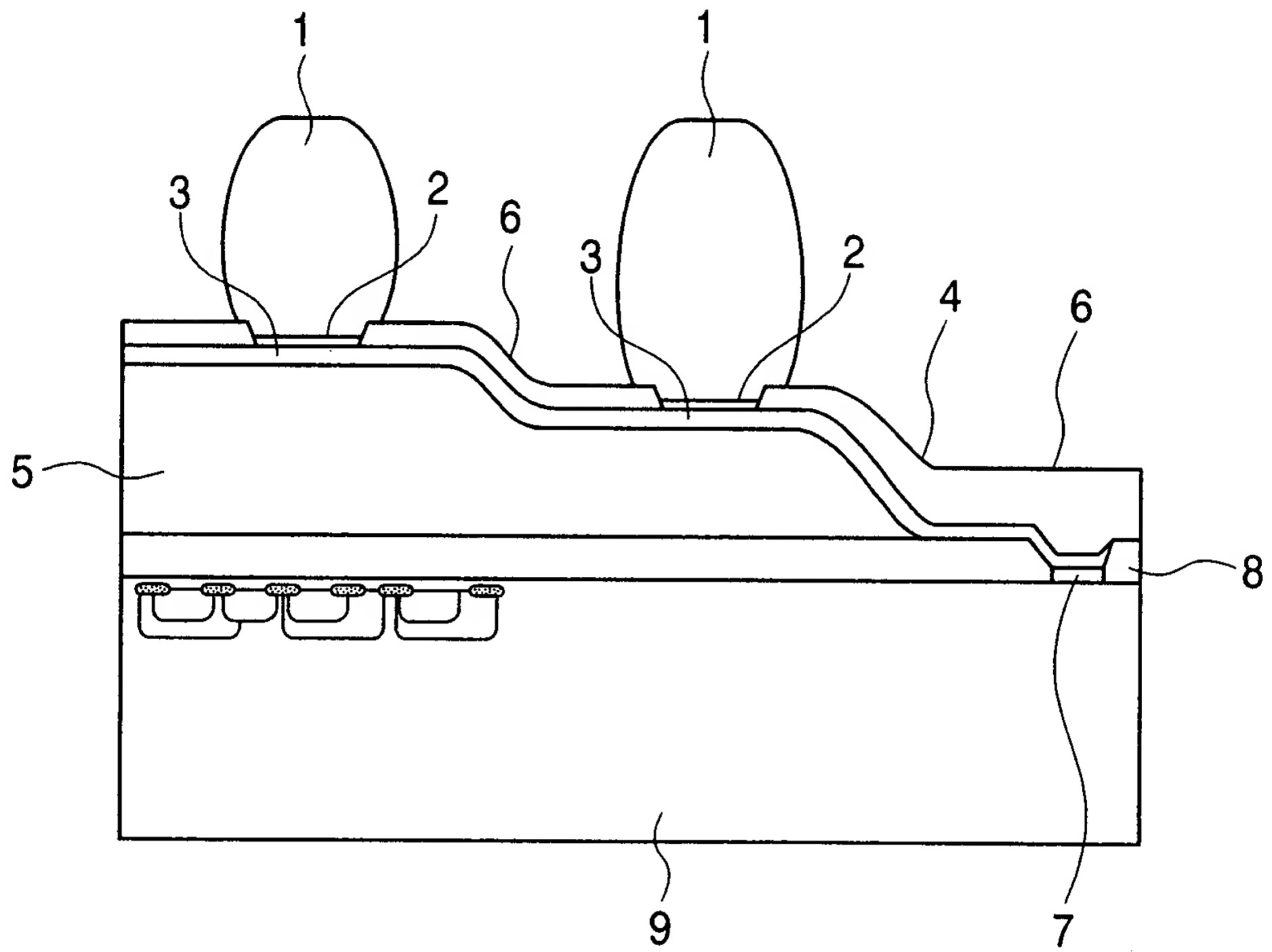
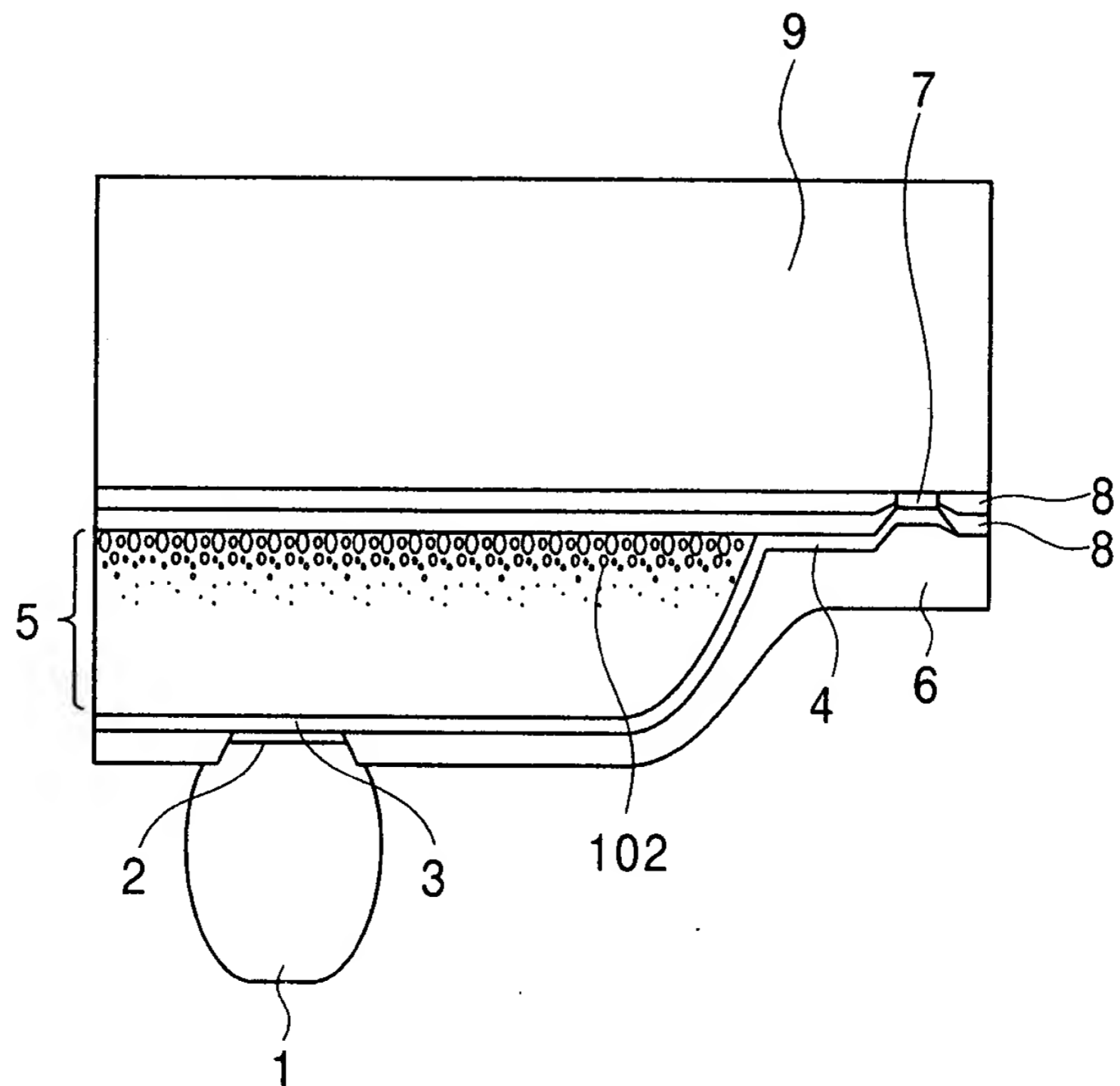


FIG. 22



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FIG. 26a

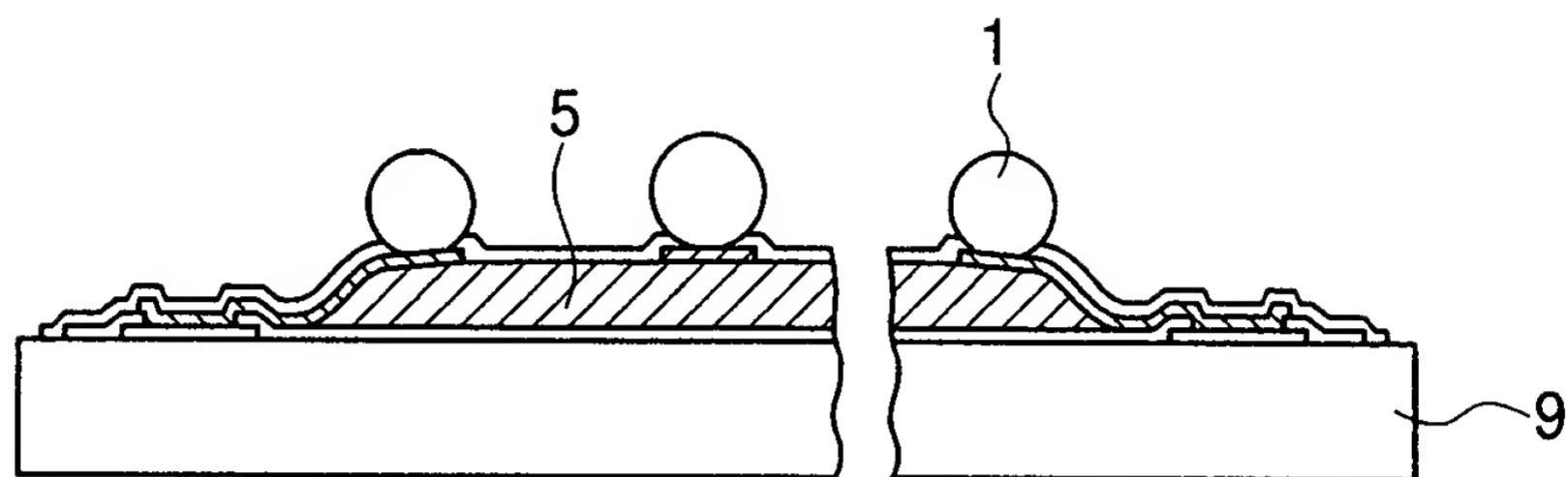


FIG. 26b

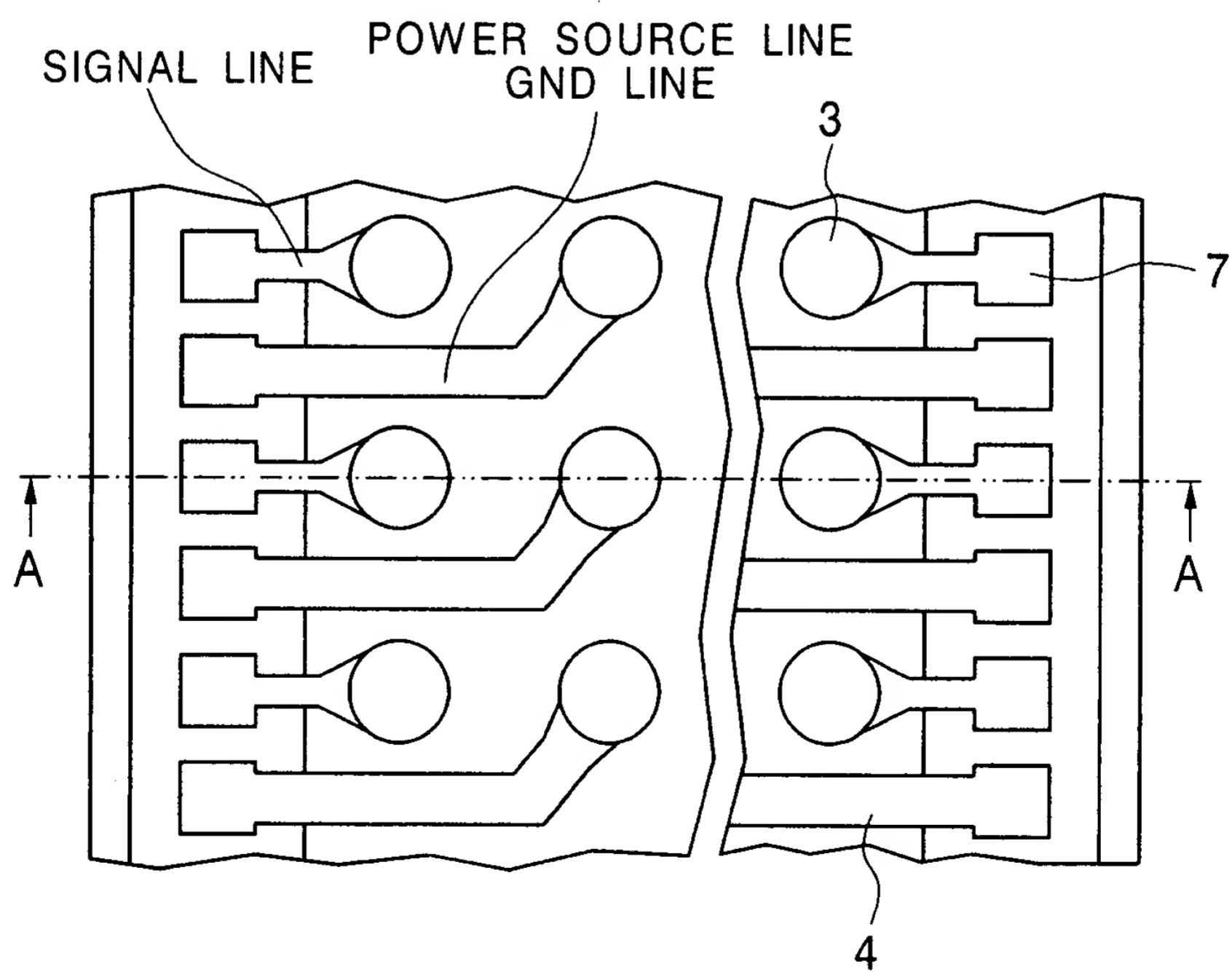


FIG. 27

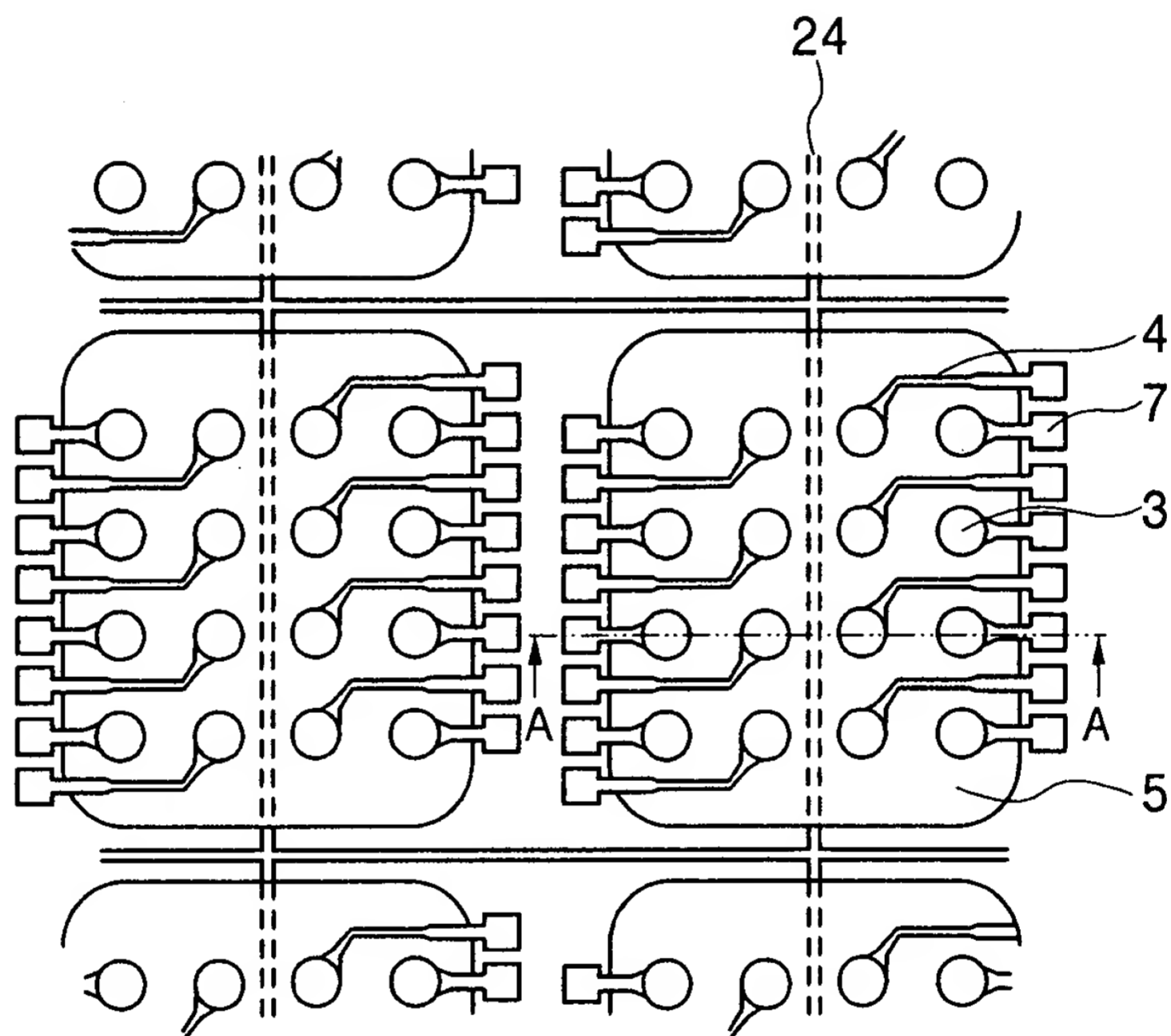


FIG. 28

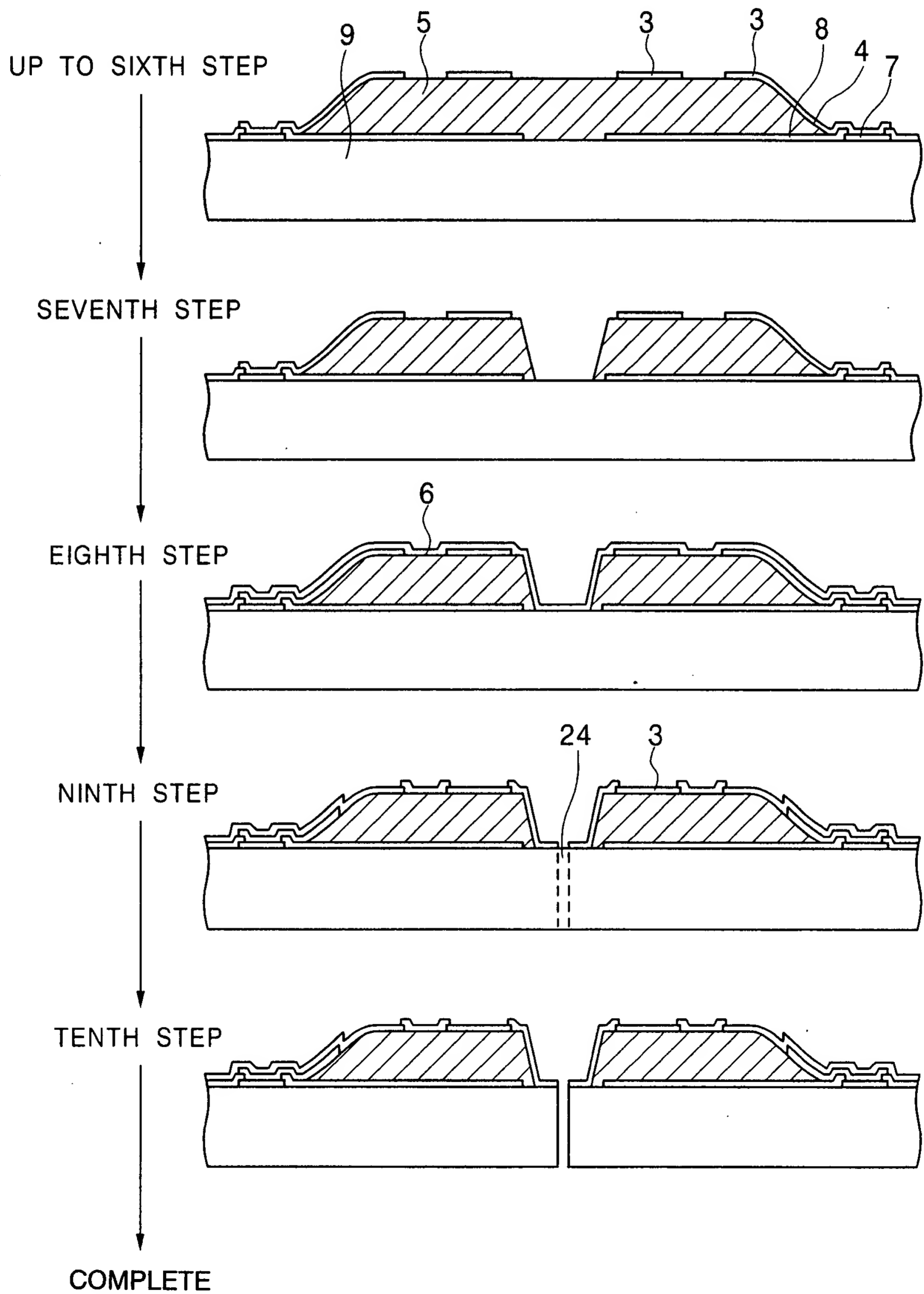


FIG. 29

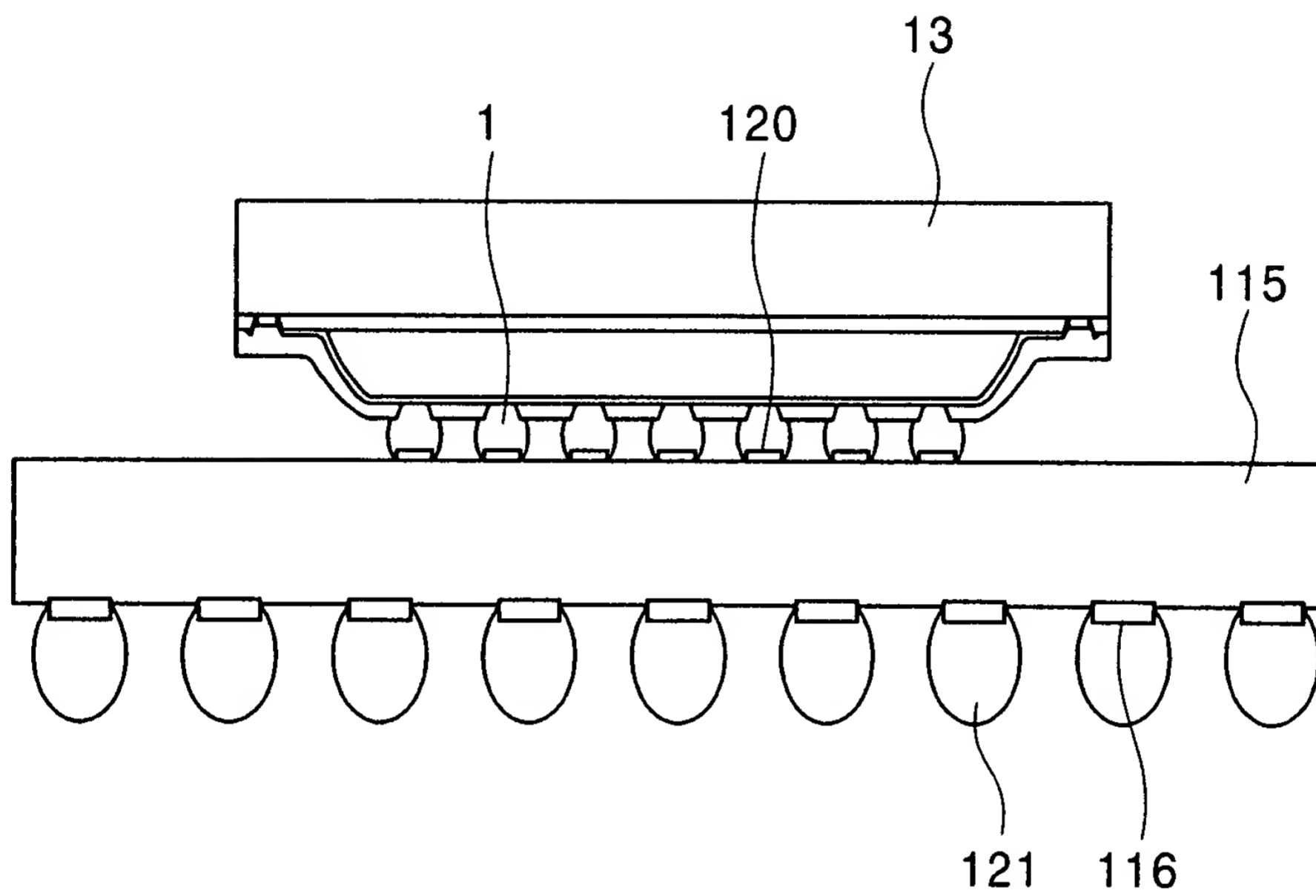


FIG. 30

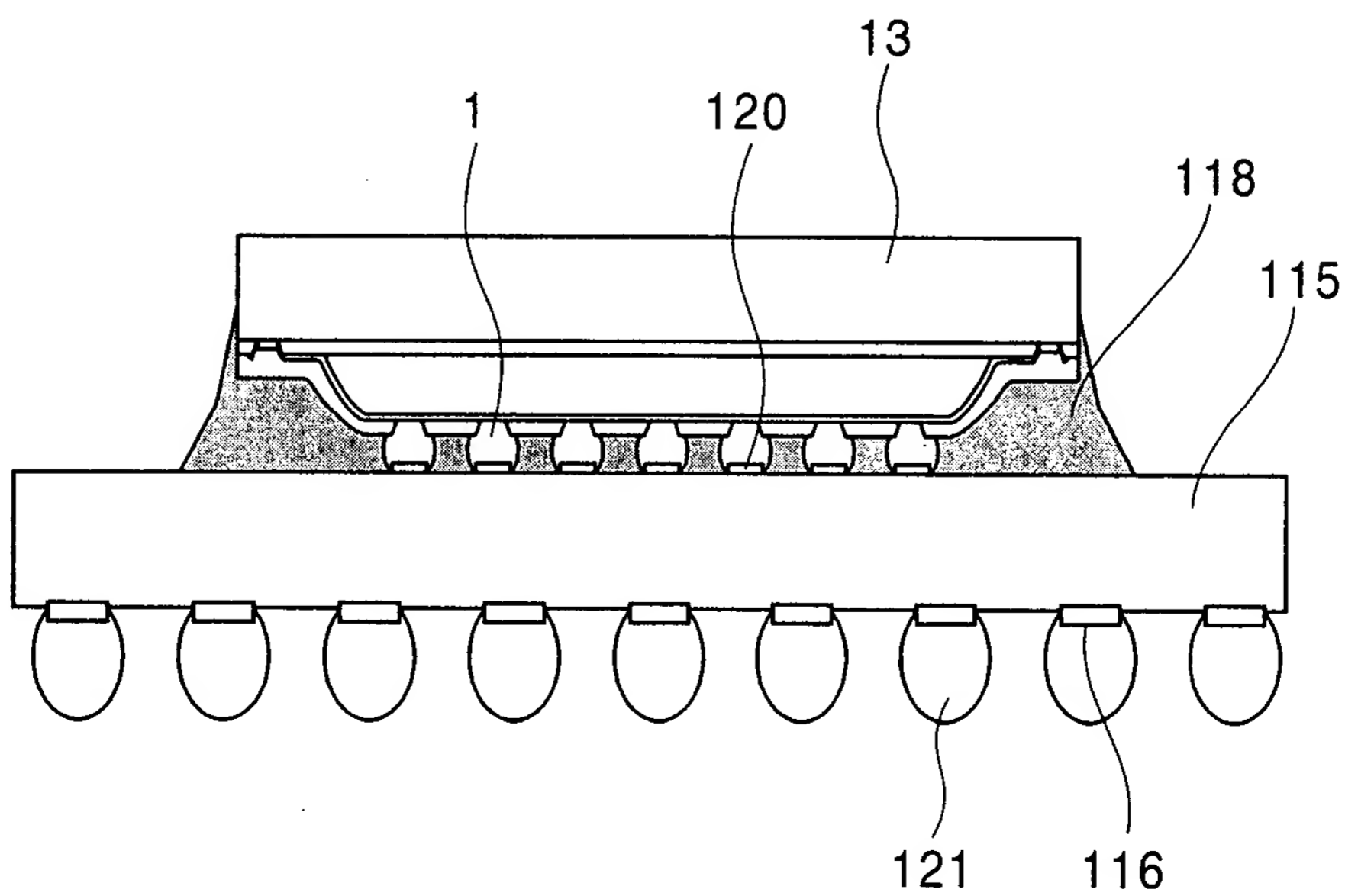


FIG. 31

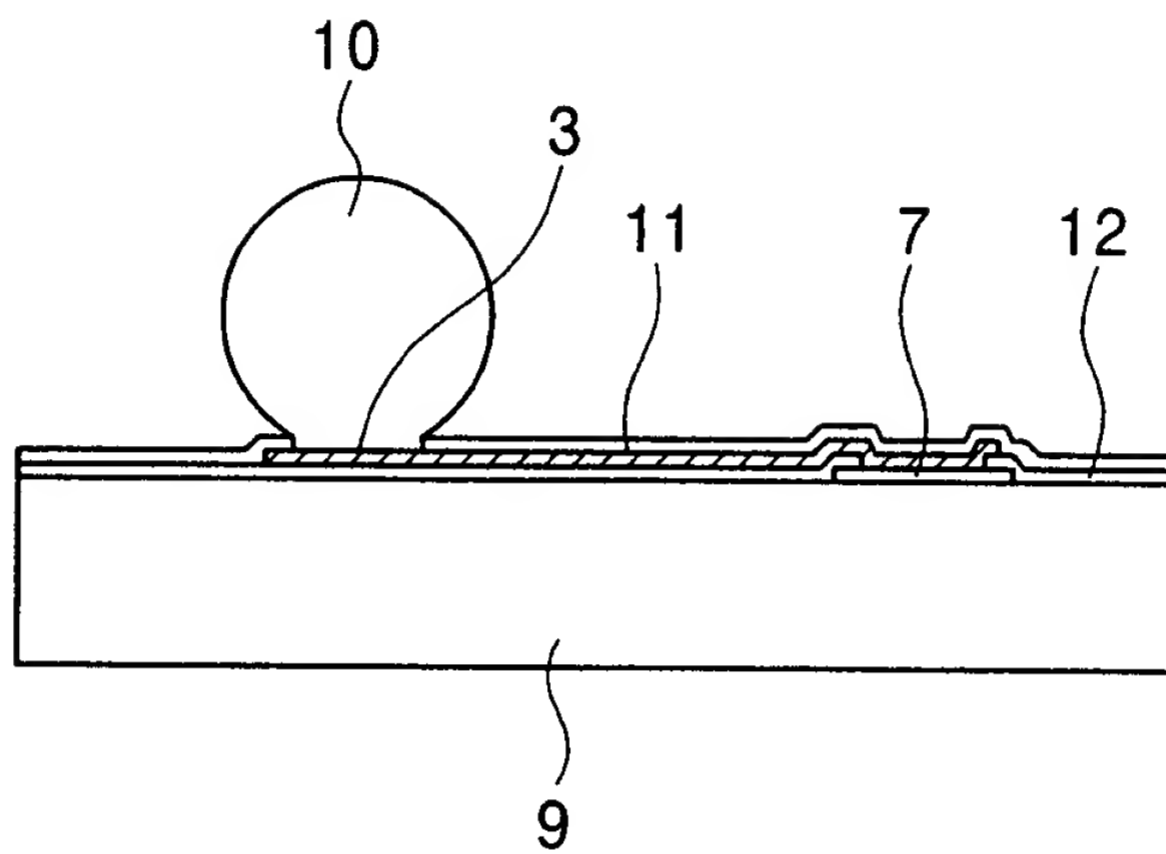


FIG. 32

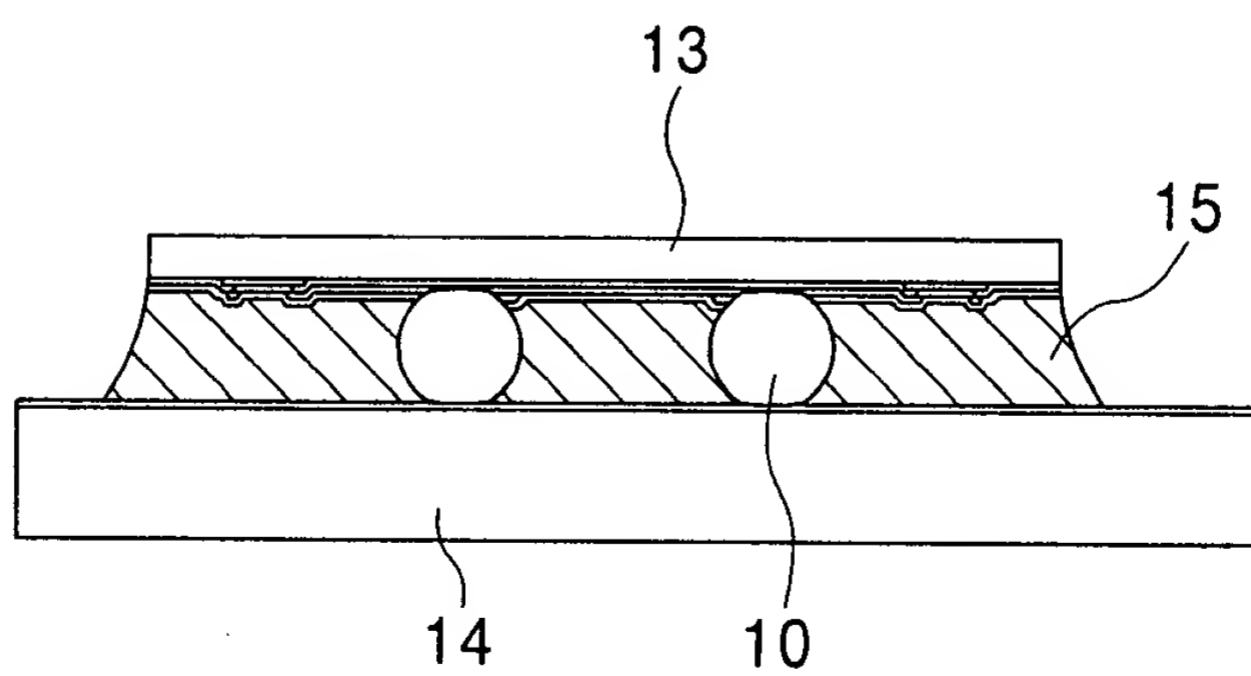


FIG. 33a

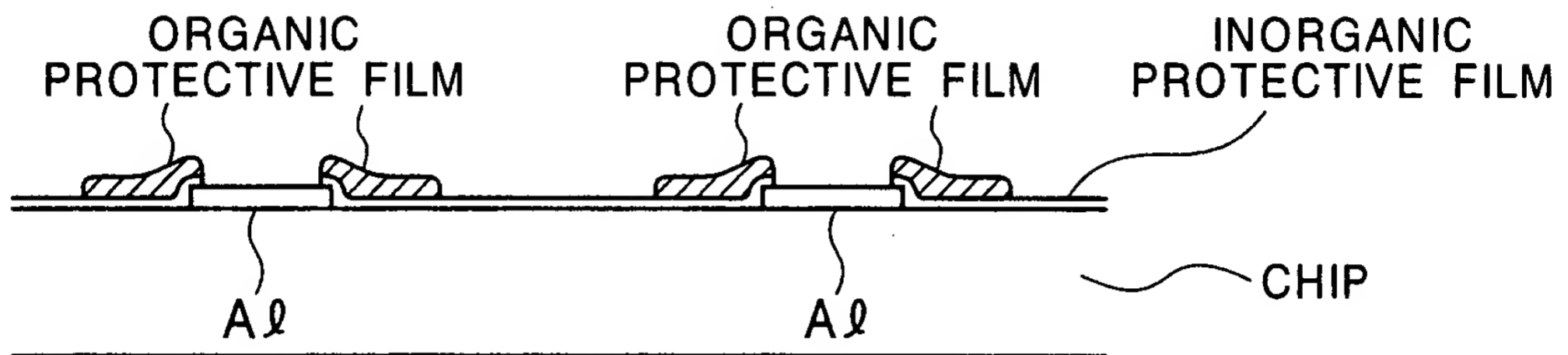
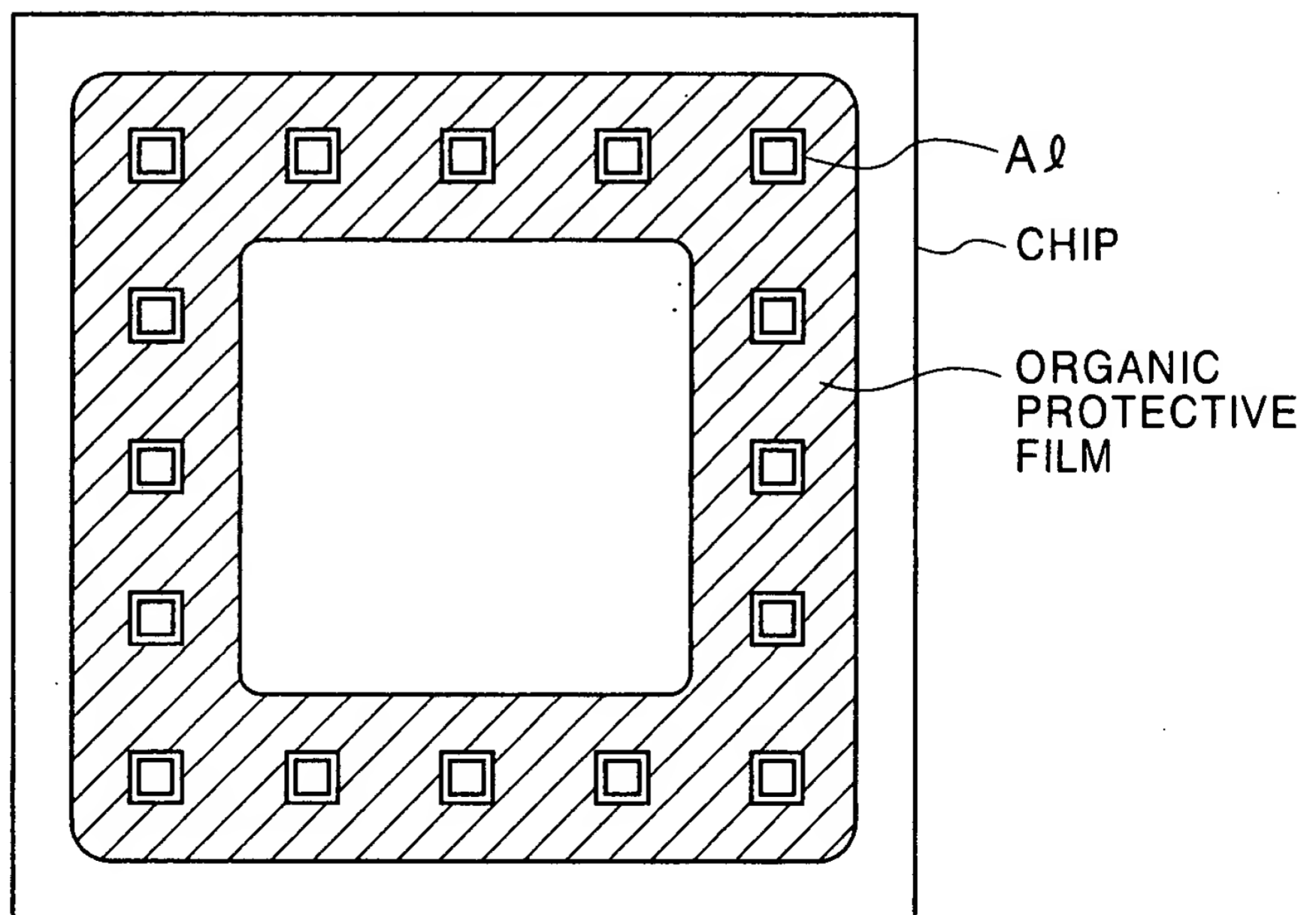
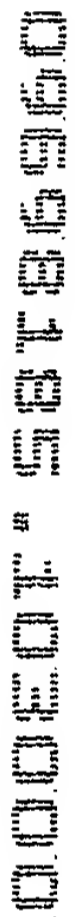


FIG. 33b



1950年12月22日



1950年12月22日

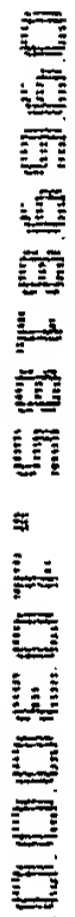
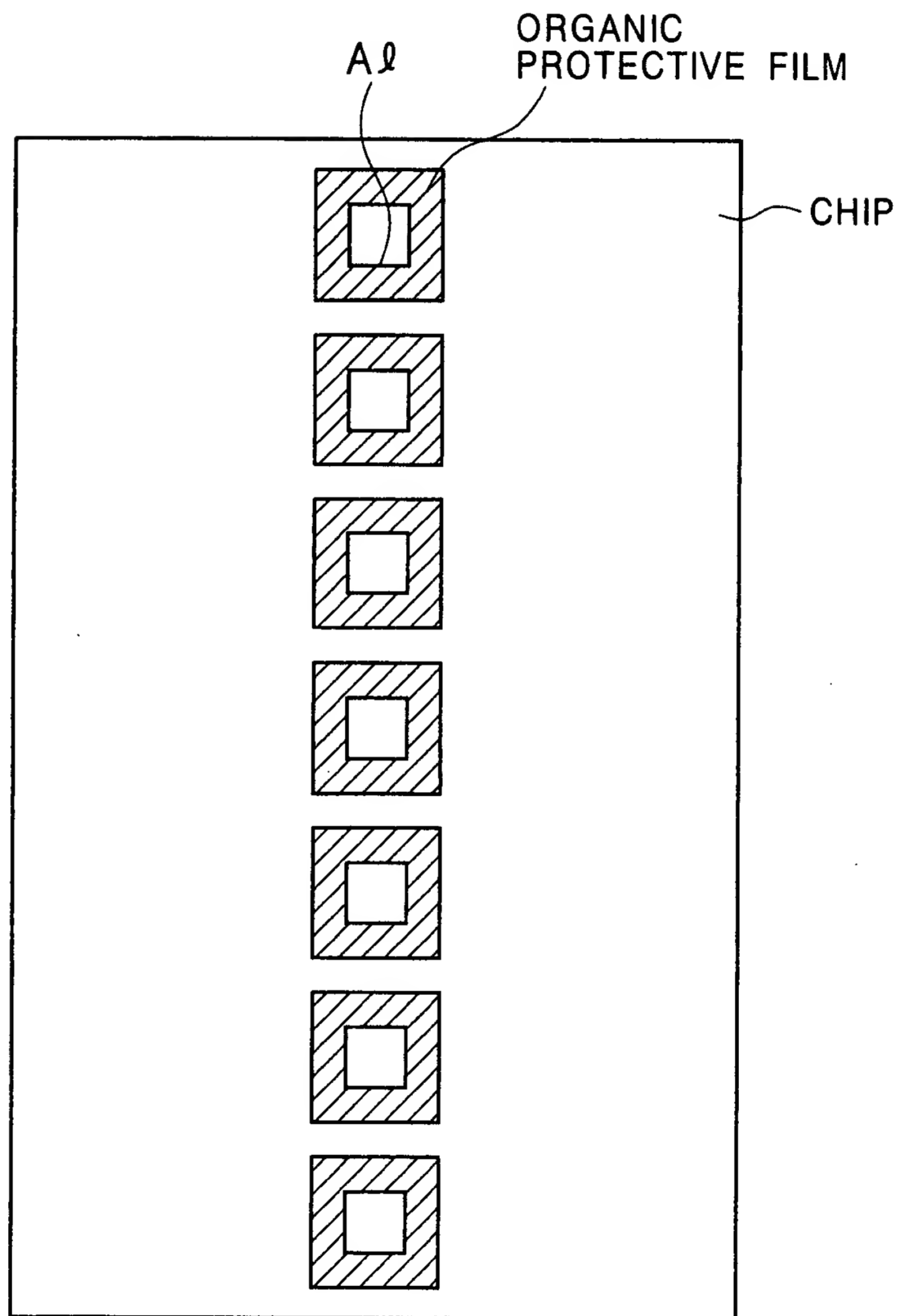


FIG. 35



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FIG. 36

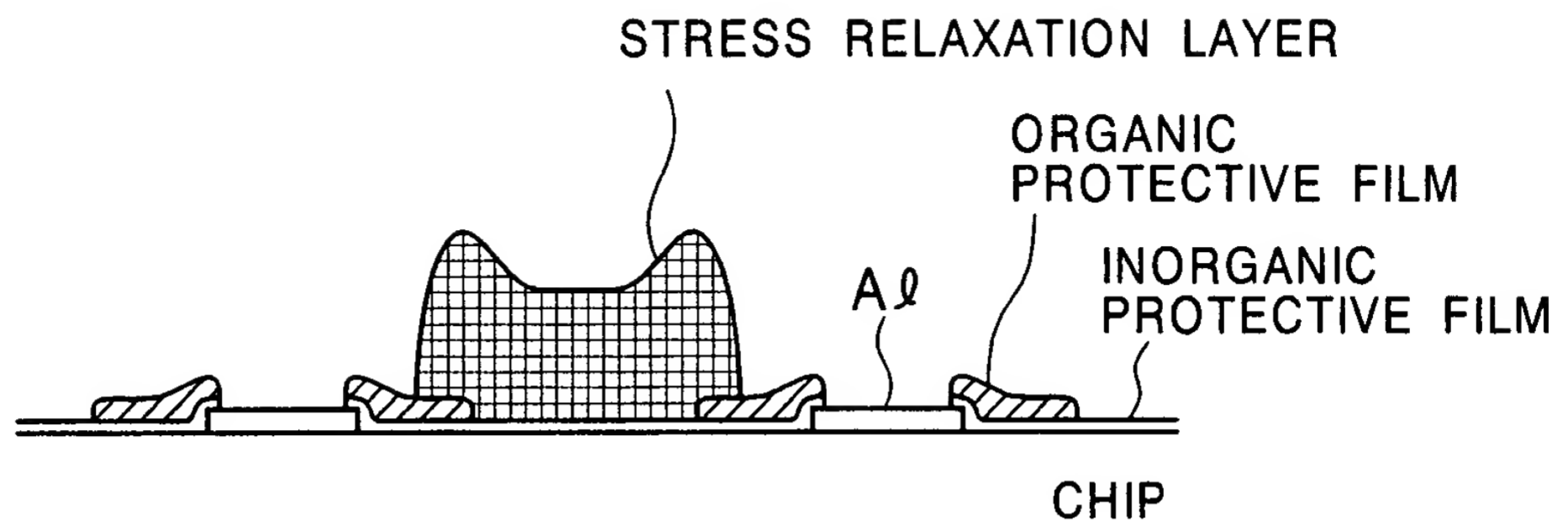


FIG. 37

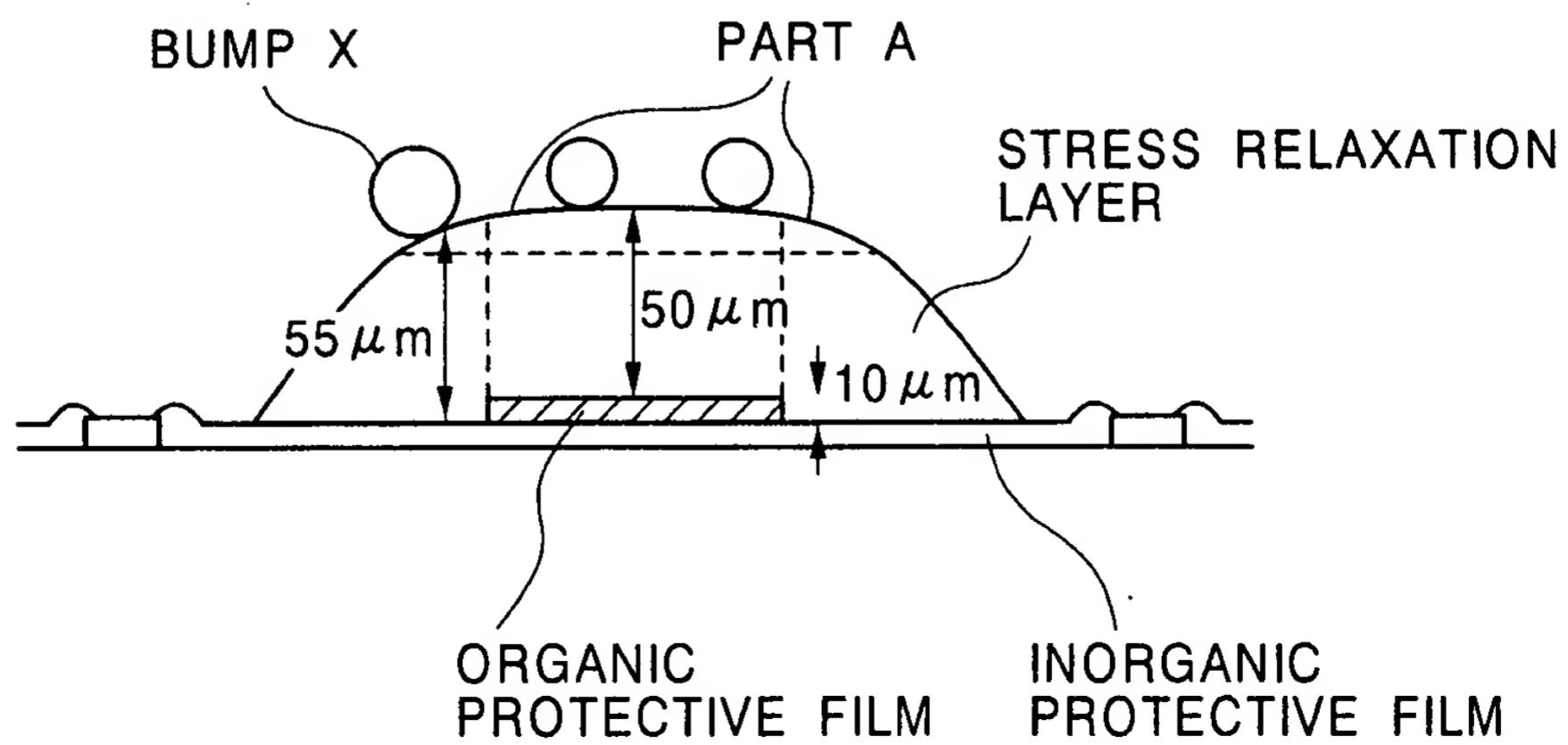


FIG. 38

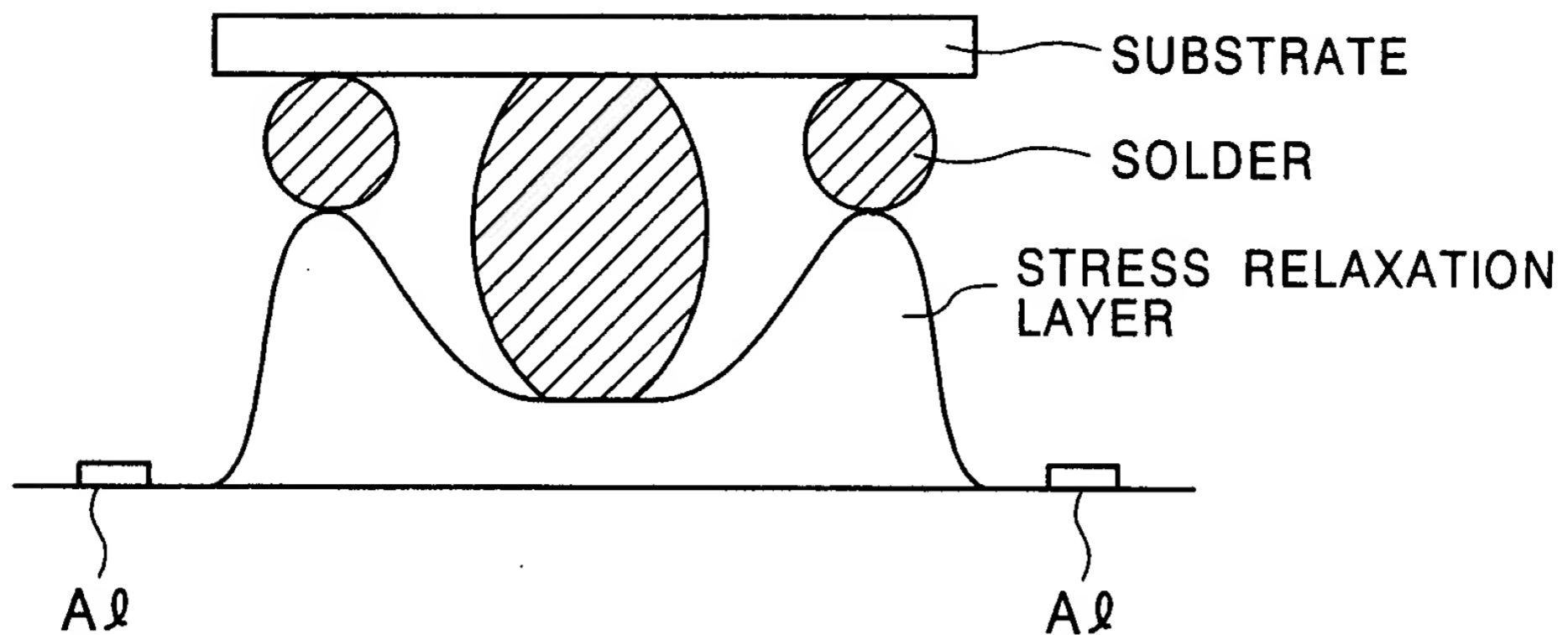


FIG. 39a

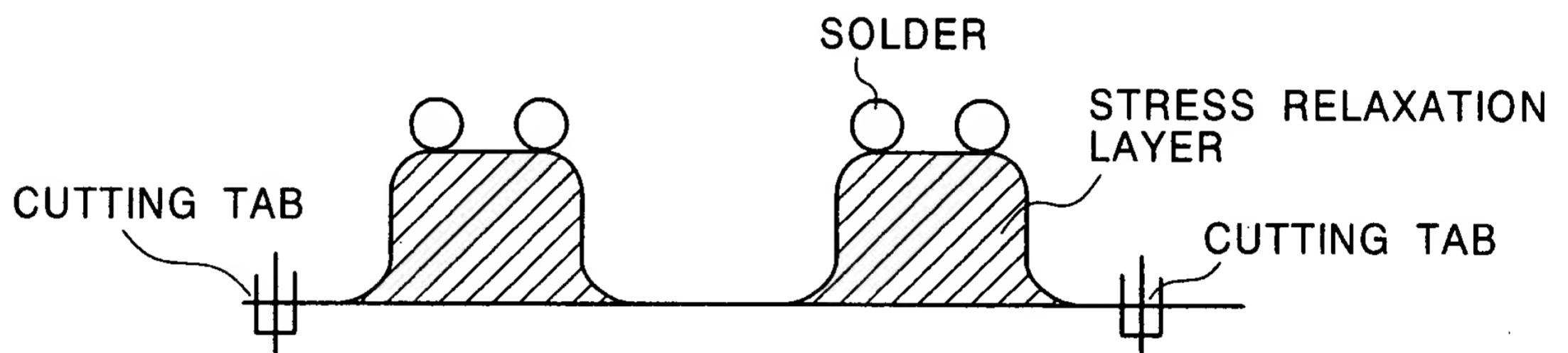


FIG. 39b

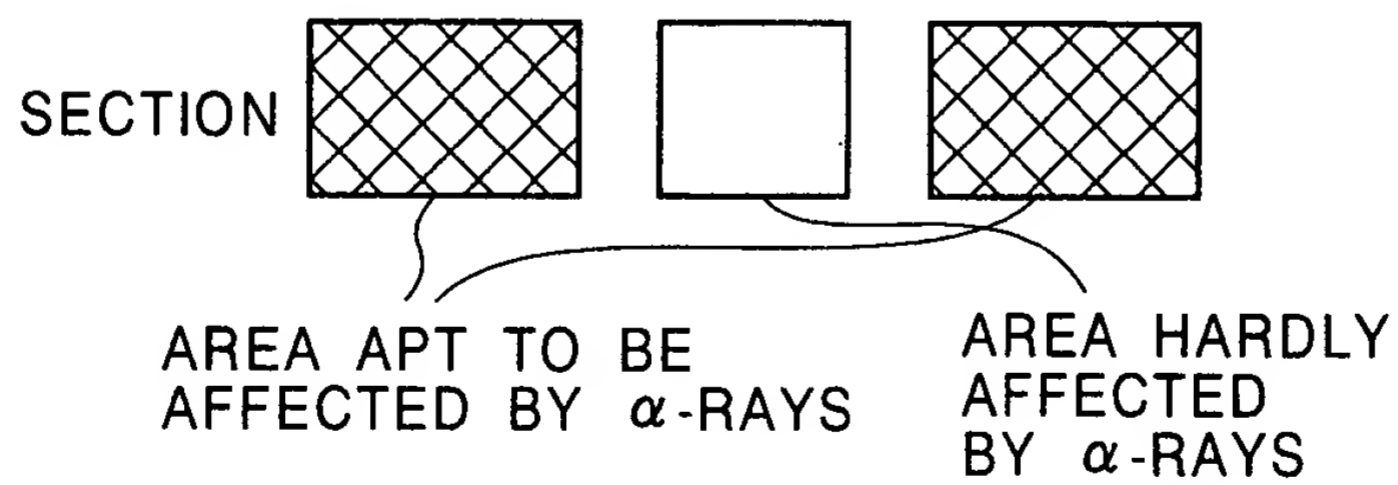


FIG. 39c

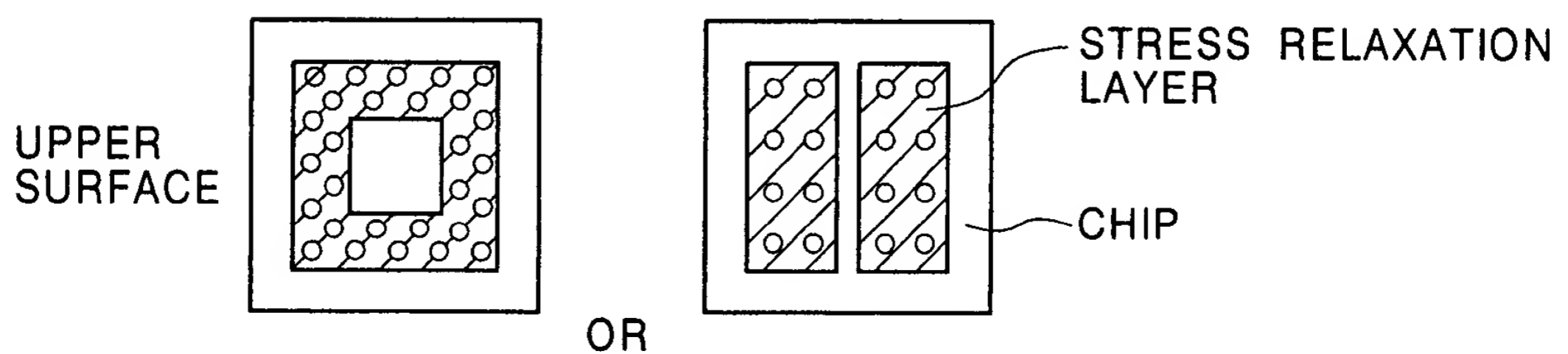


FIG. 40

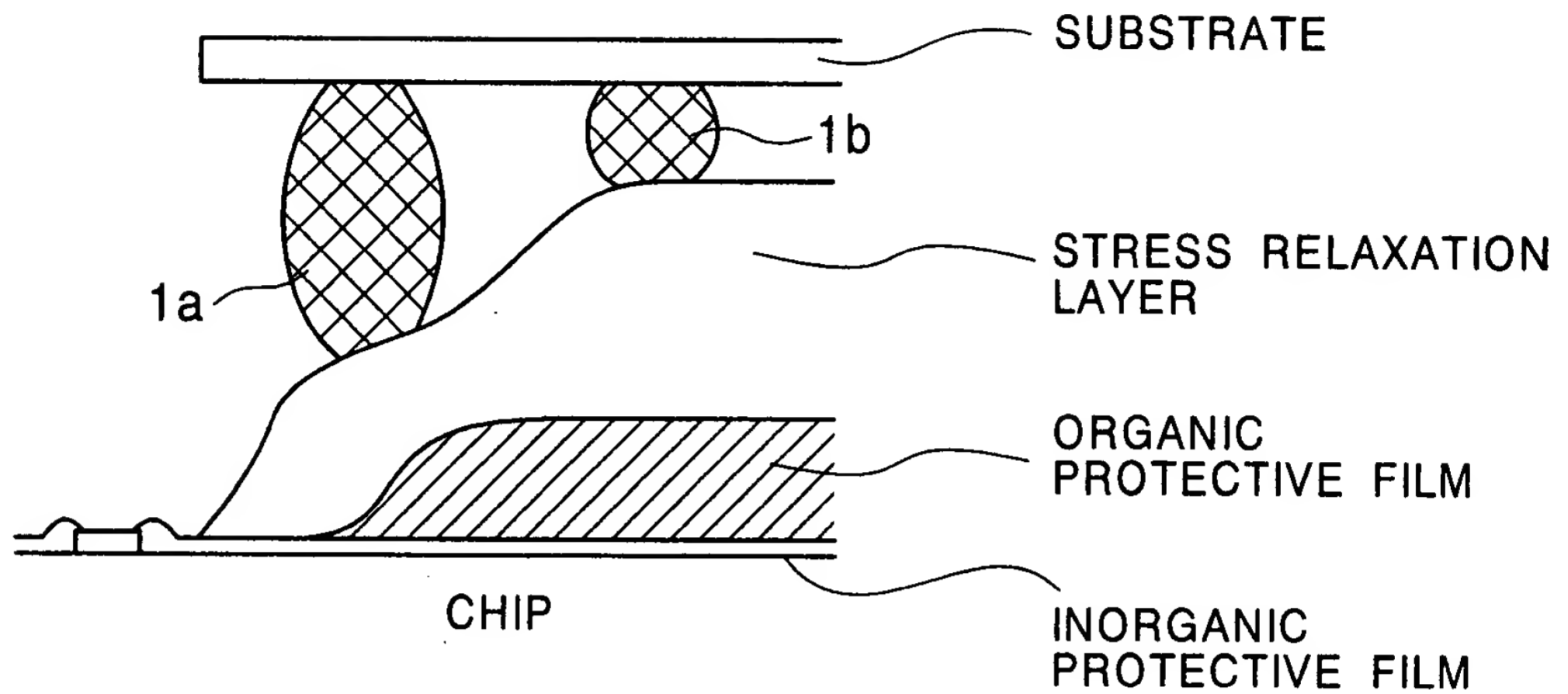
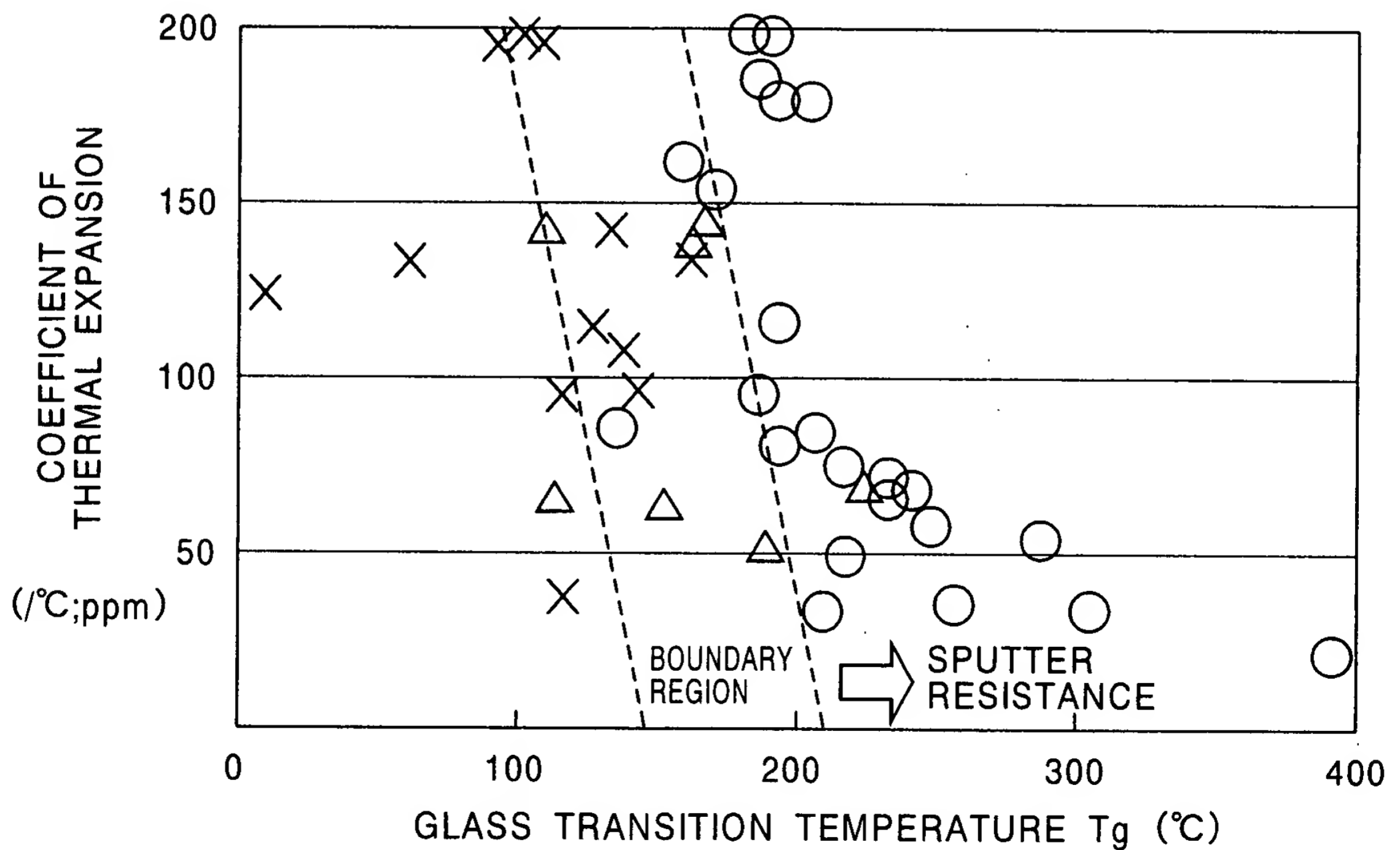


FIG. 41



PHYSICAL VALUES AND SPUTTER RESISTANCE OF
STRESS RELAXATION LAYER CANDIDATE MATERIAL
(X: OCCURRENCE OF CRACKS, Δ : OCCURRENCE OF WRINKLE,
 \circ : NO ABNORMALITY)